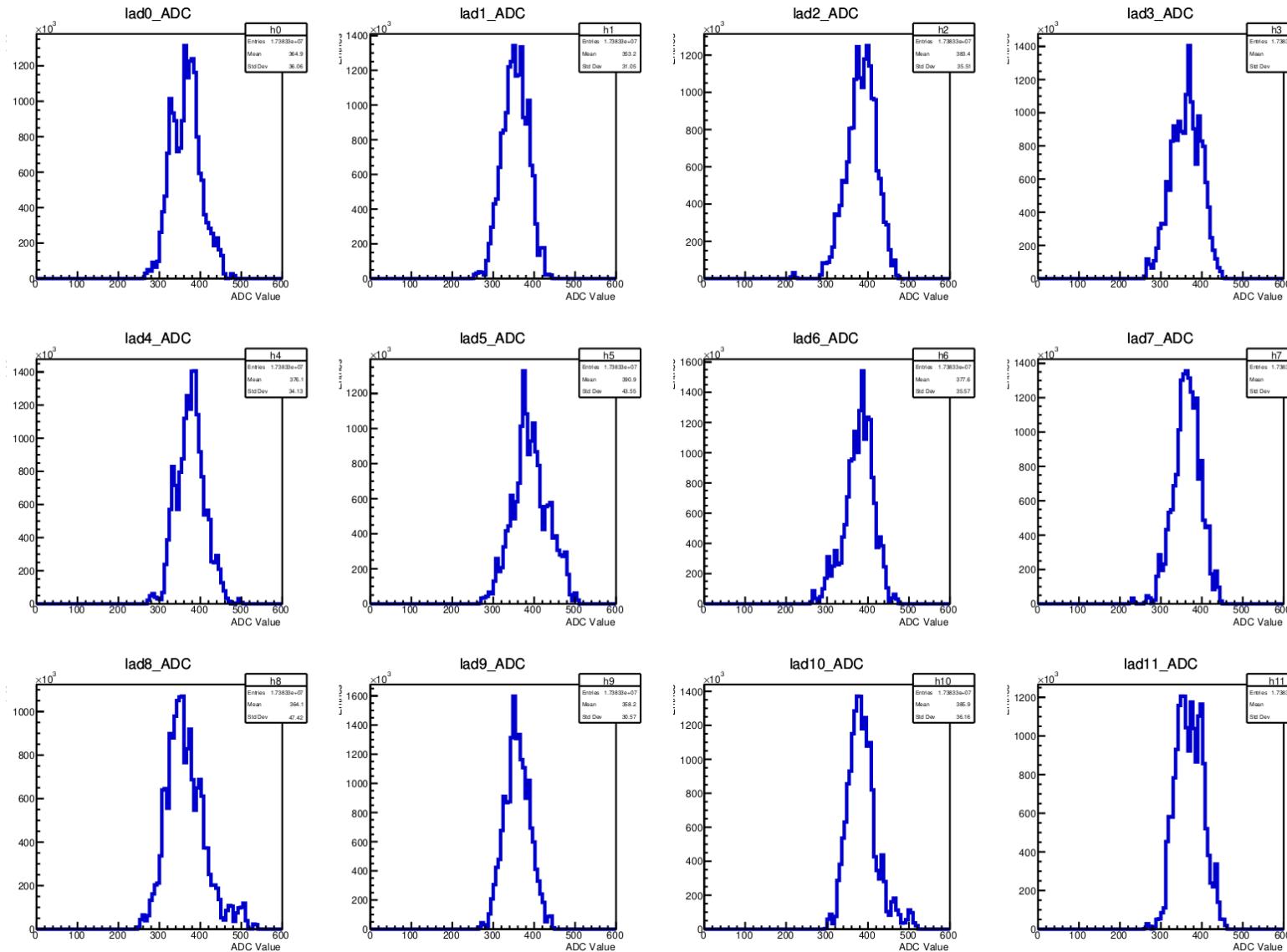
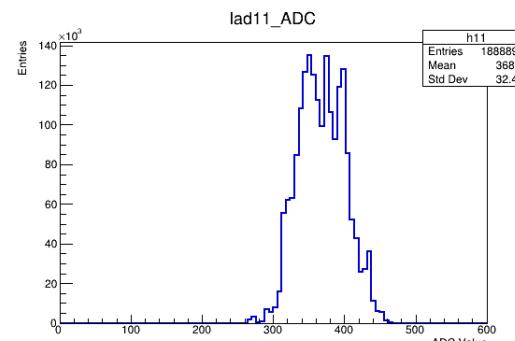
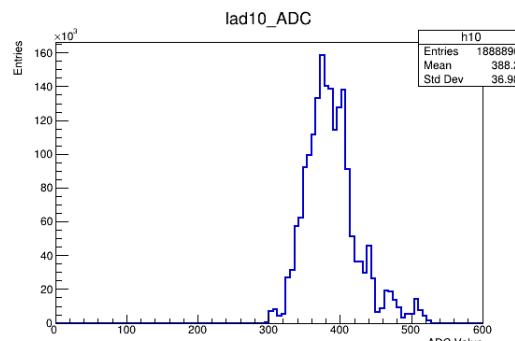
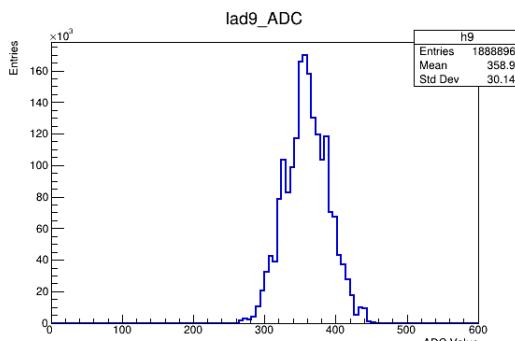
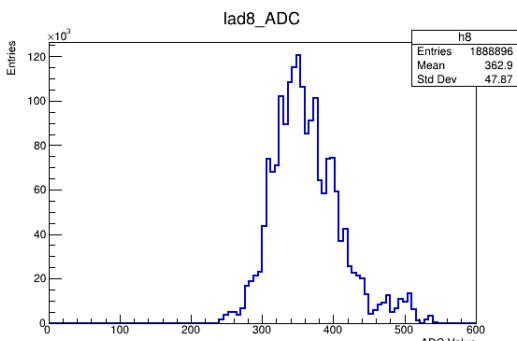
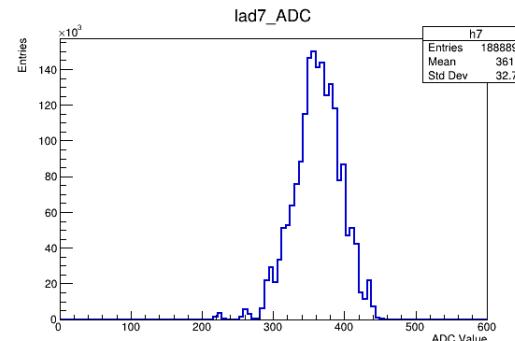
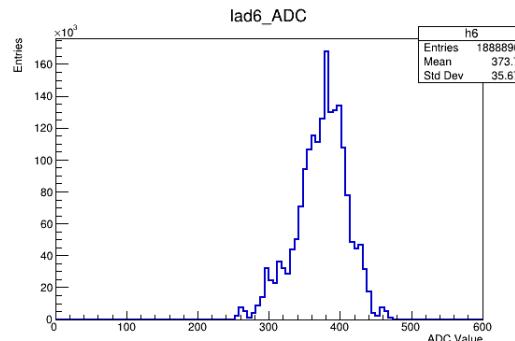
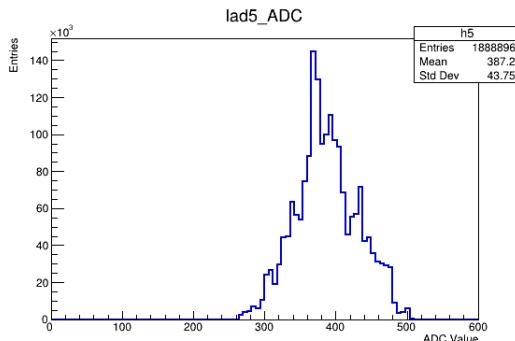
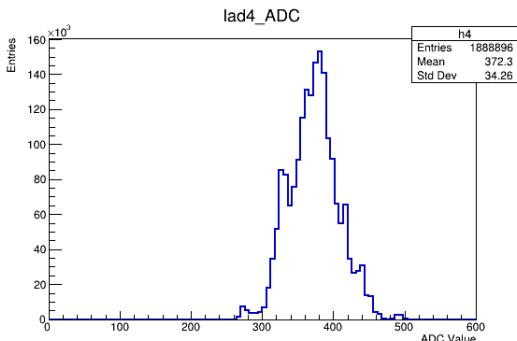
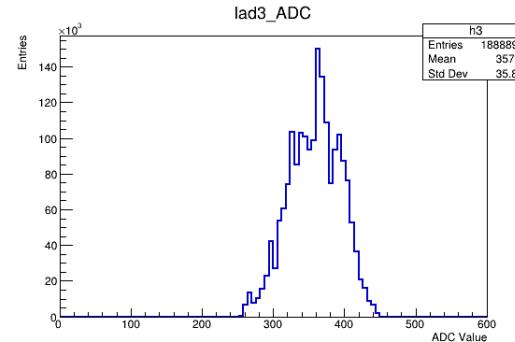
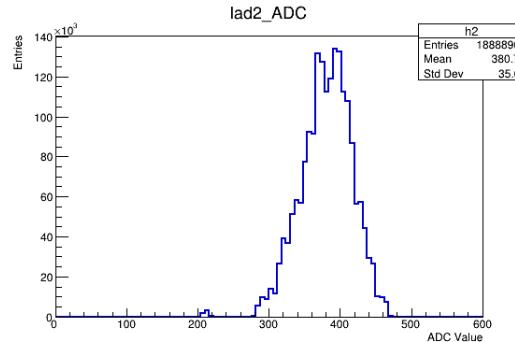
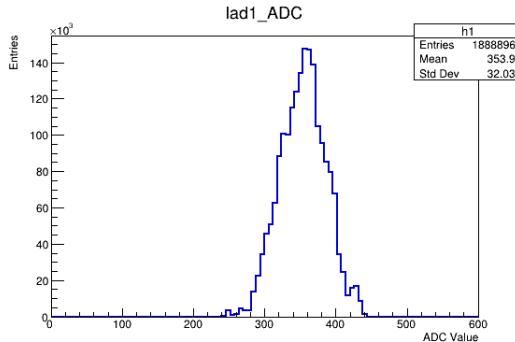
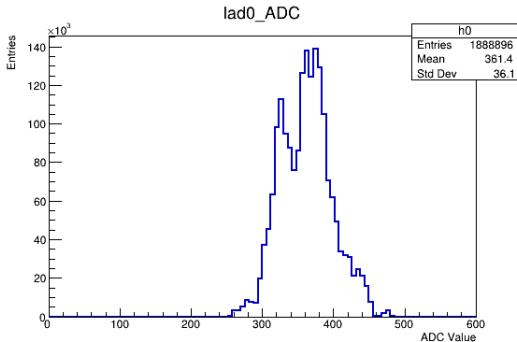


紫台进展

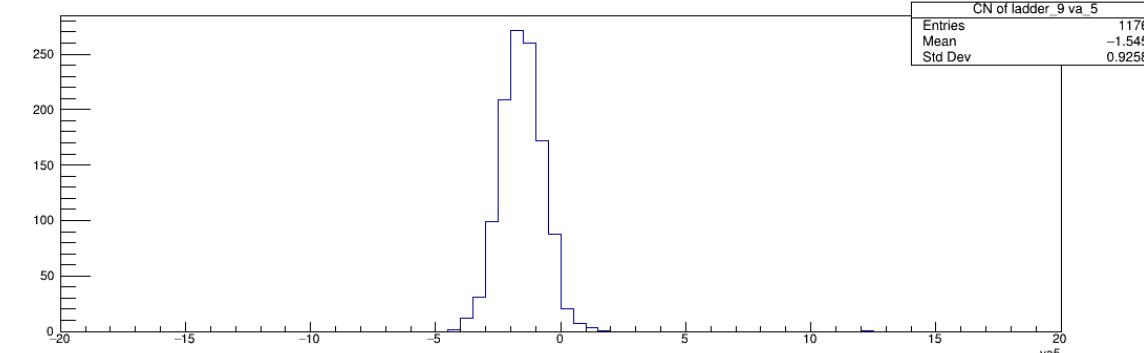
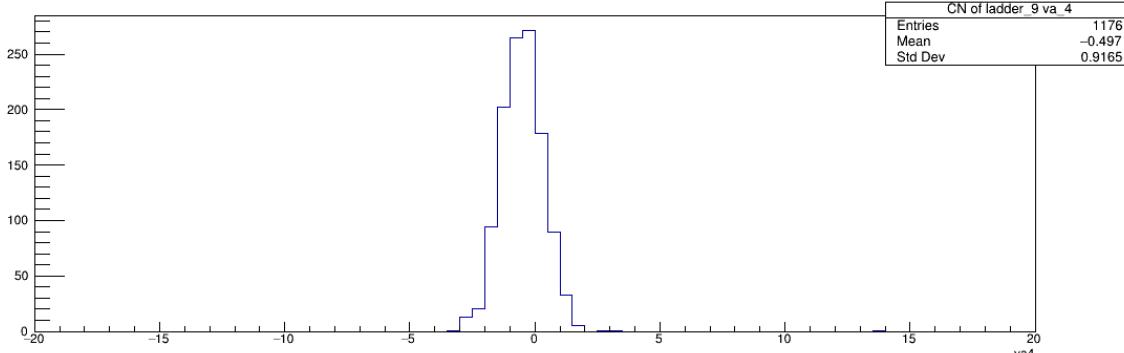
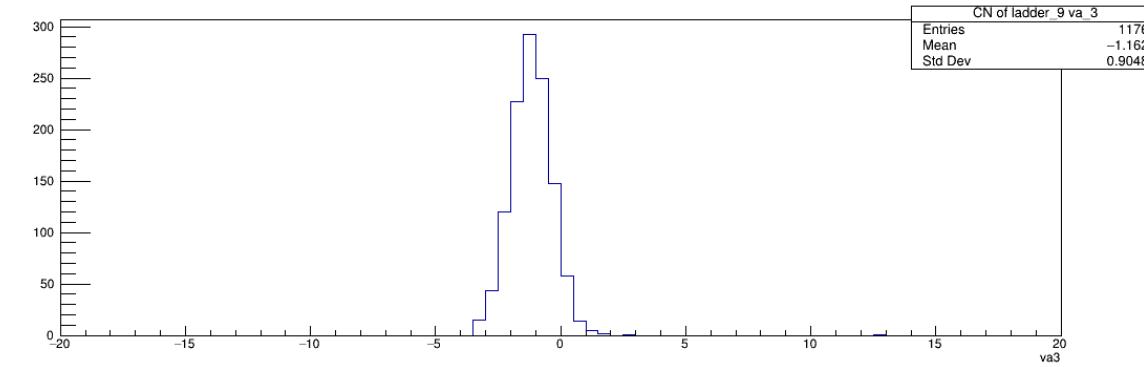
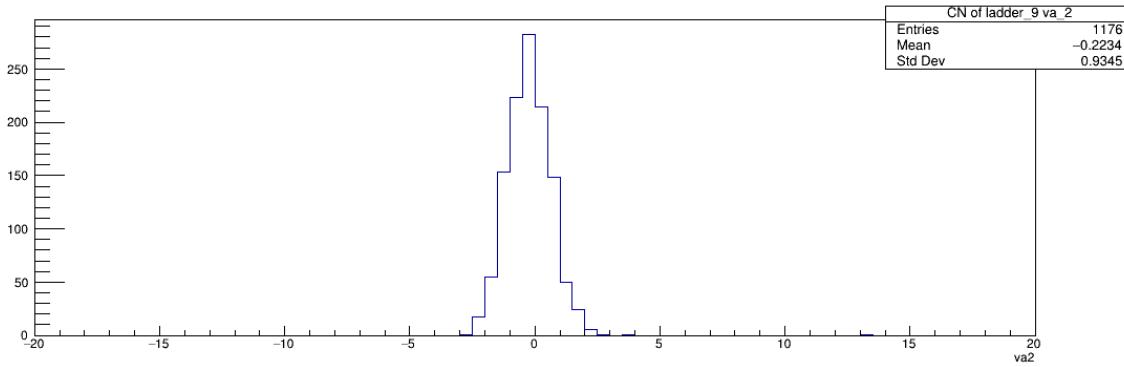
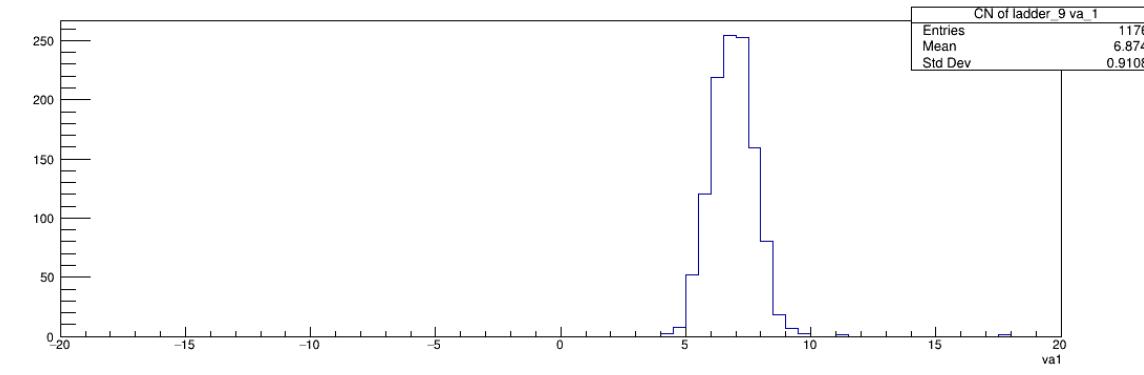
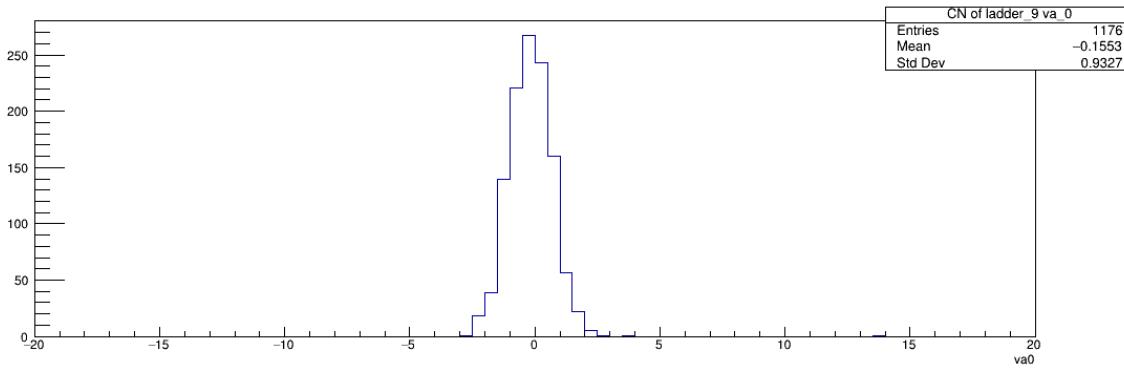
Ped ADC of 12 panel



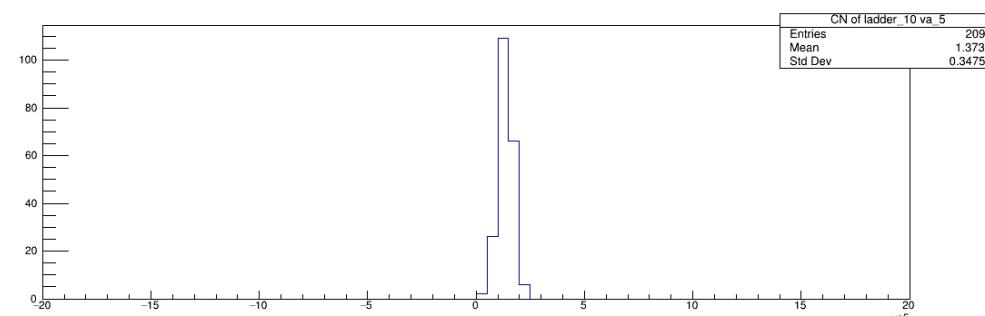
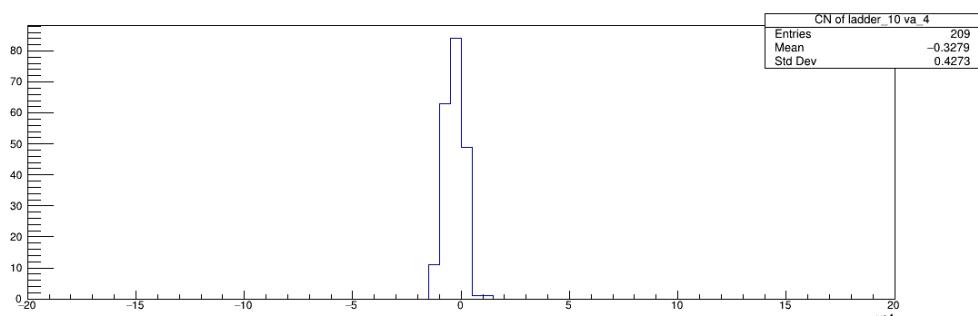
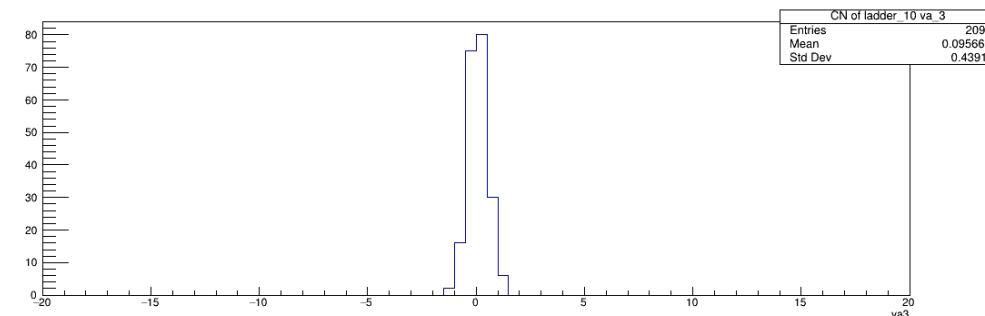
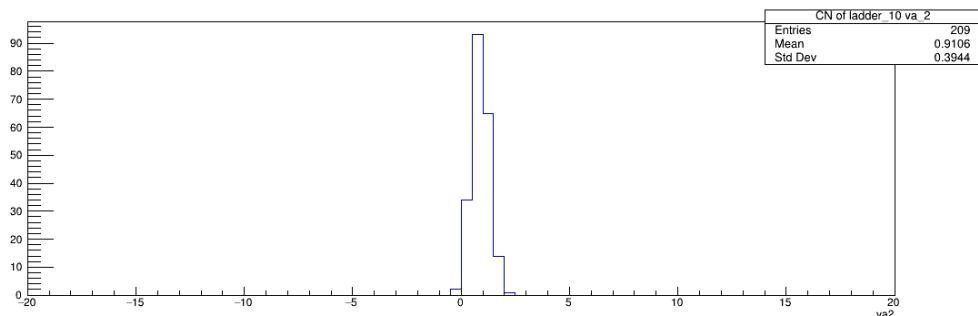
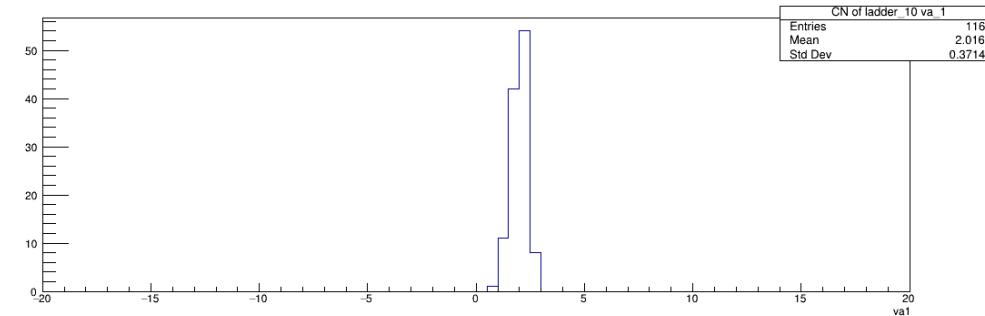
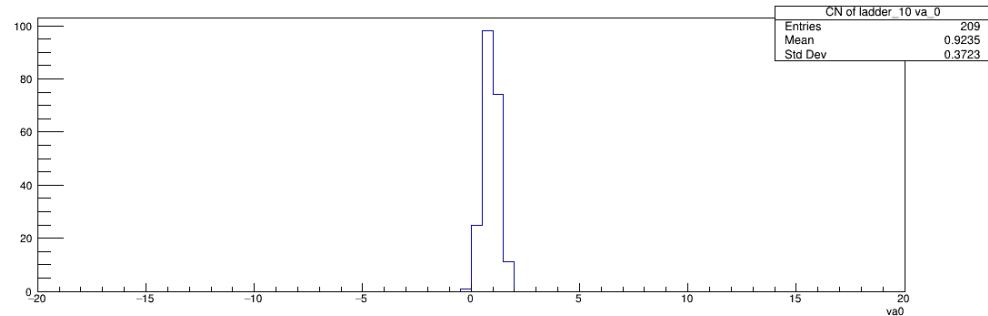
ADC of events



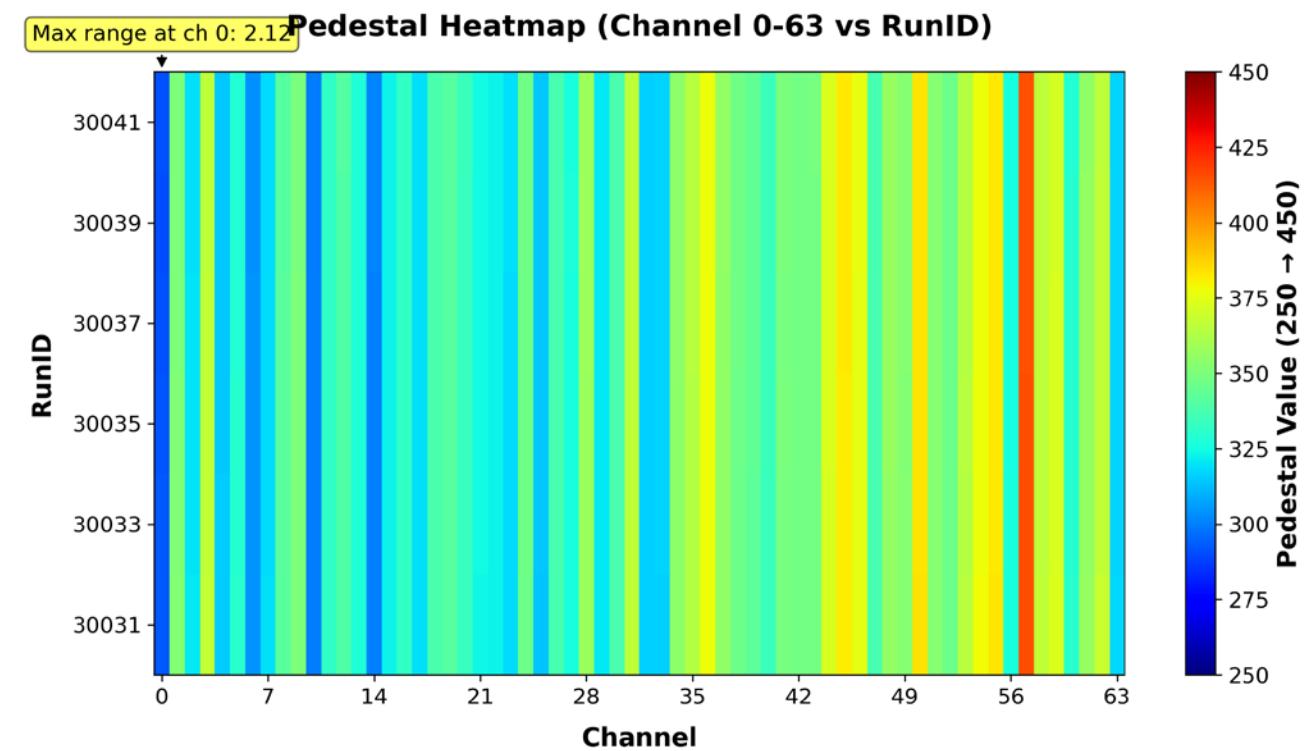
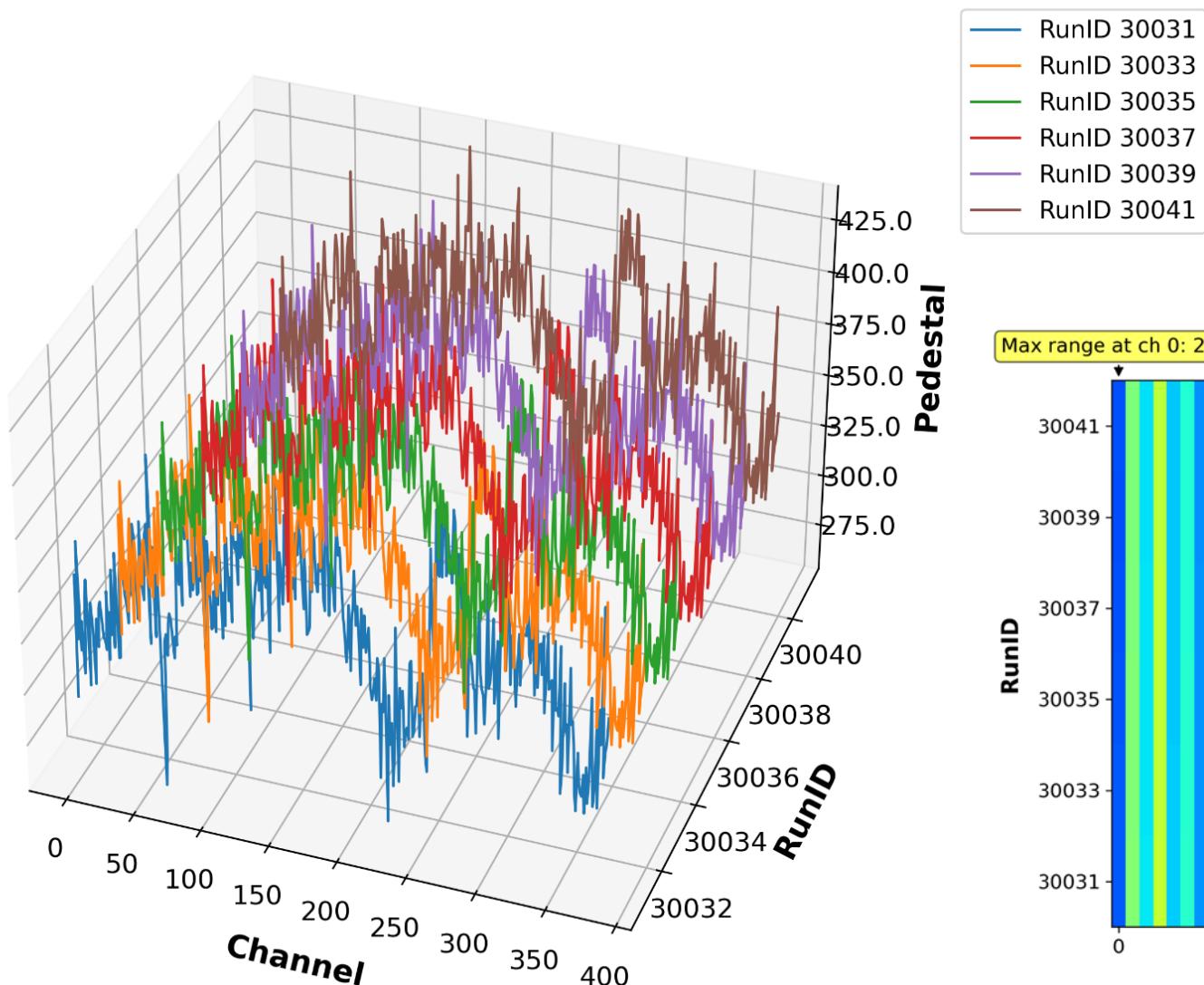
Werid CN noise

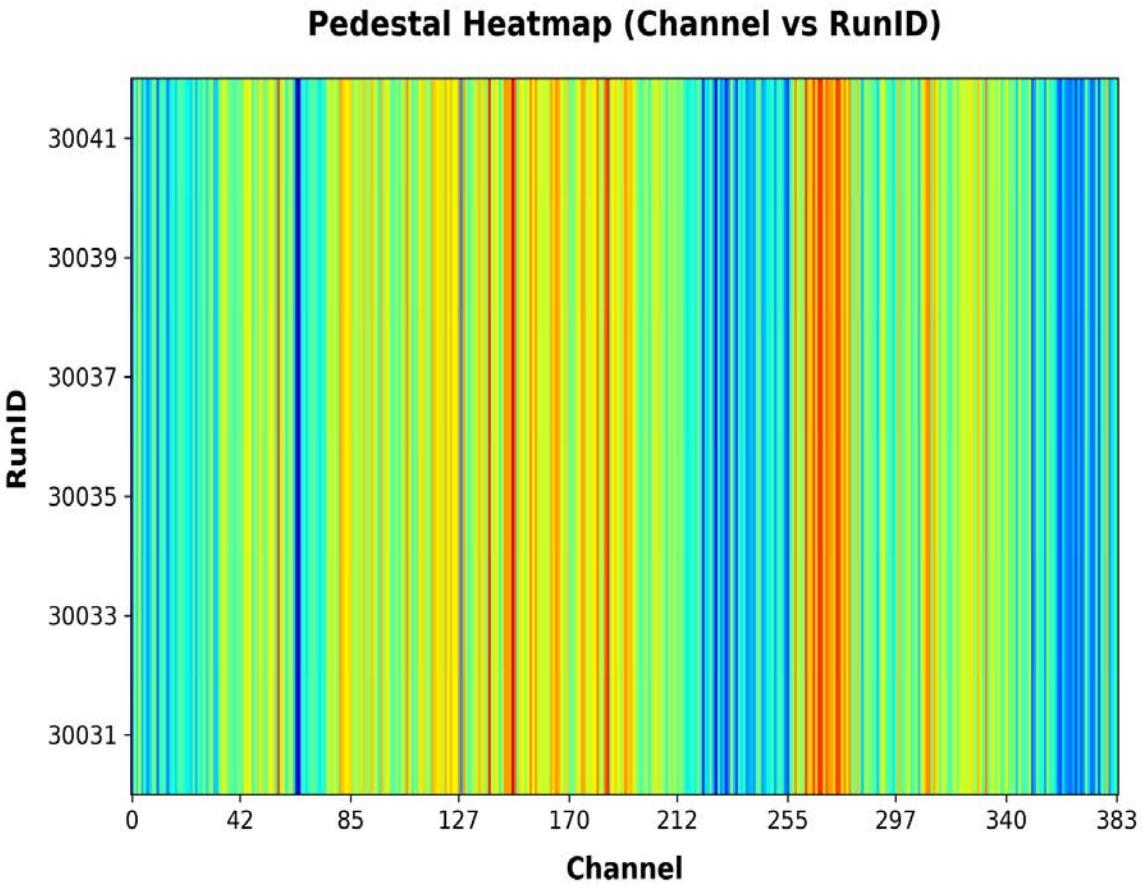


```
if(fabs(ADC[i][j] - pedestal[i][j]) < 1.5*noise[i][j])
```

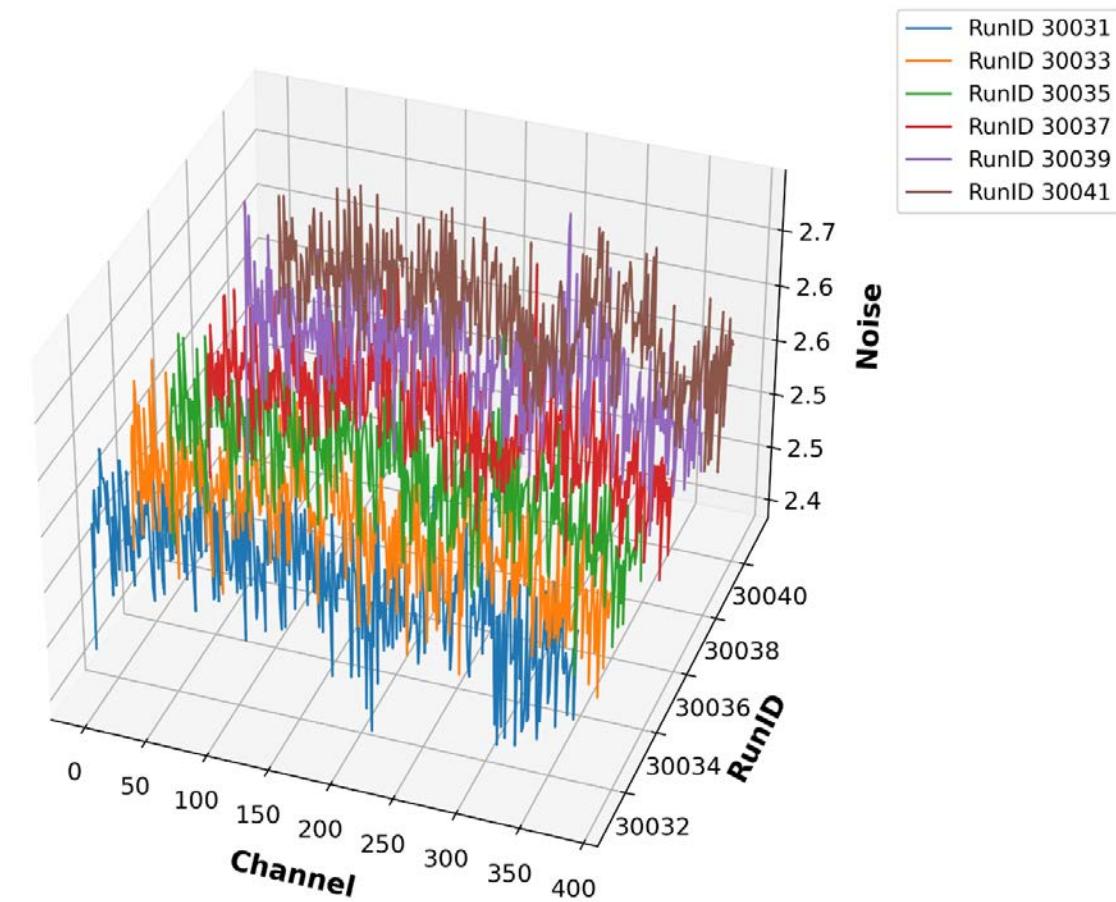


Pedestal vs Channel across Runs





Noise vs Channel across Runs



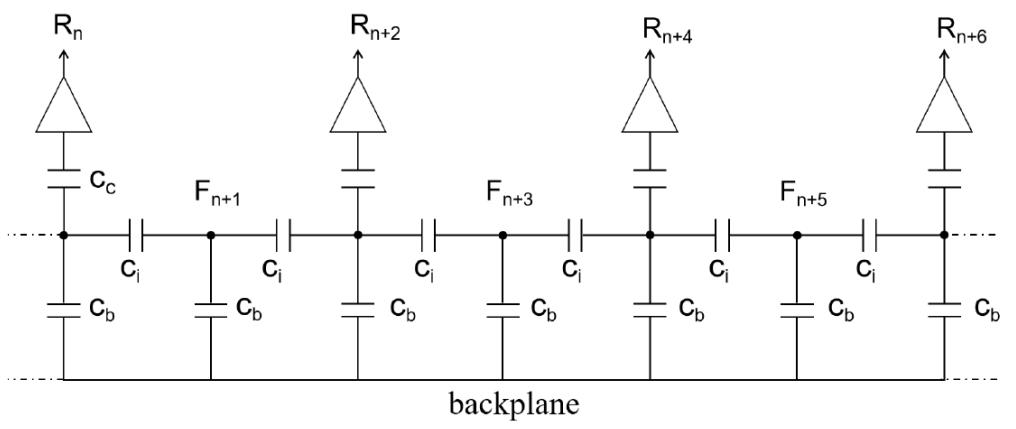
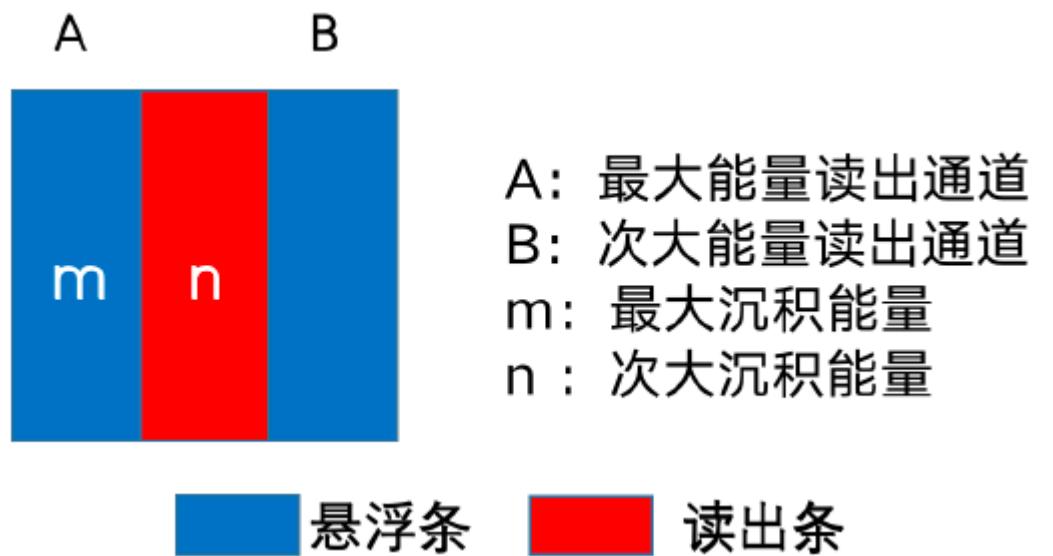
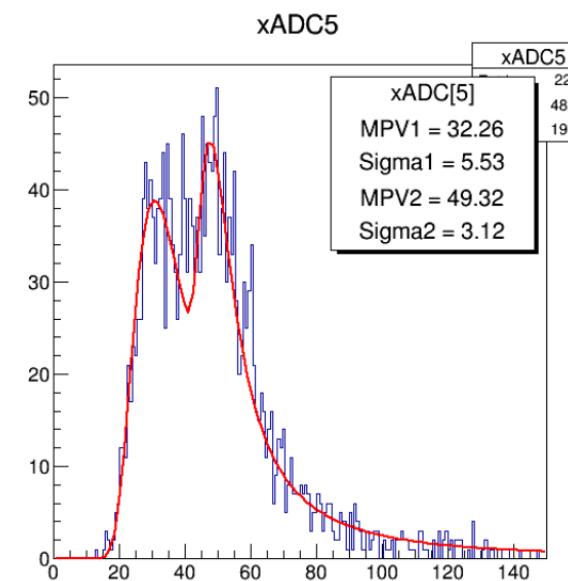
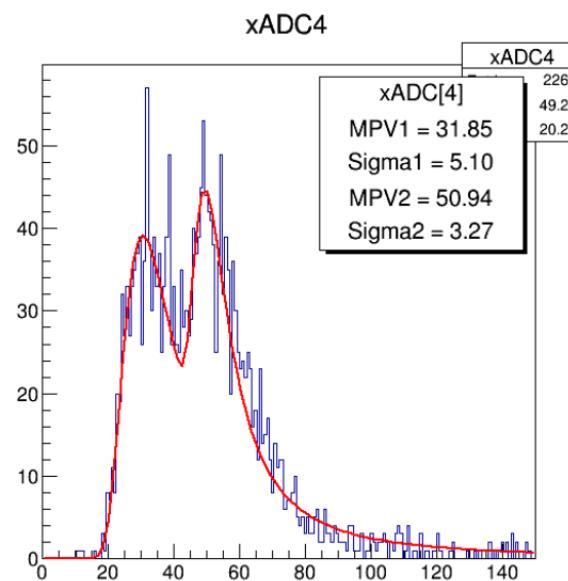
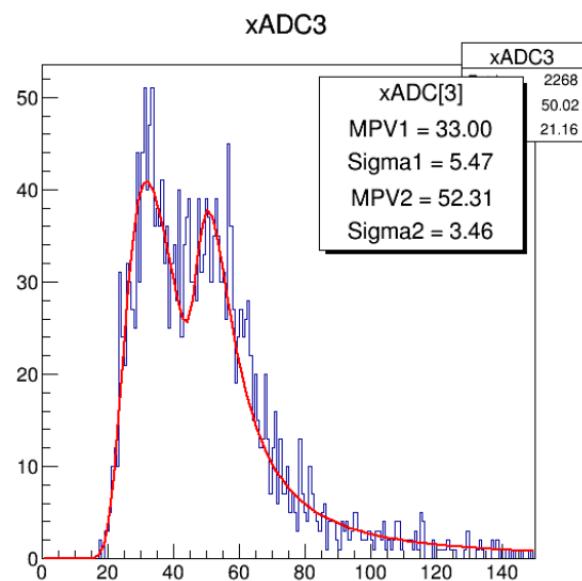
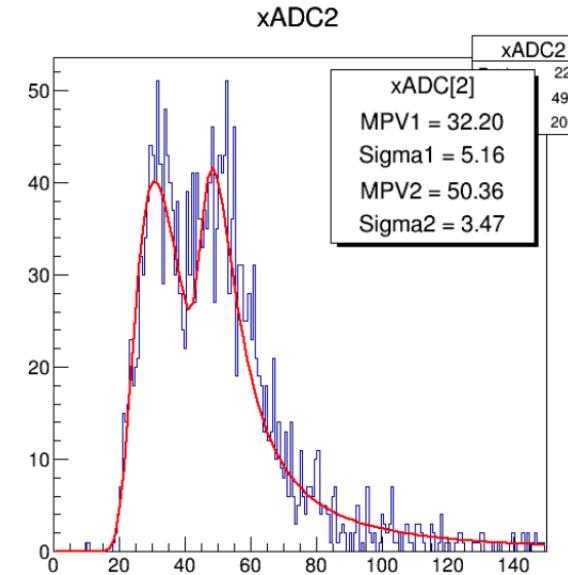
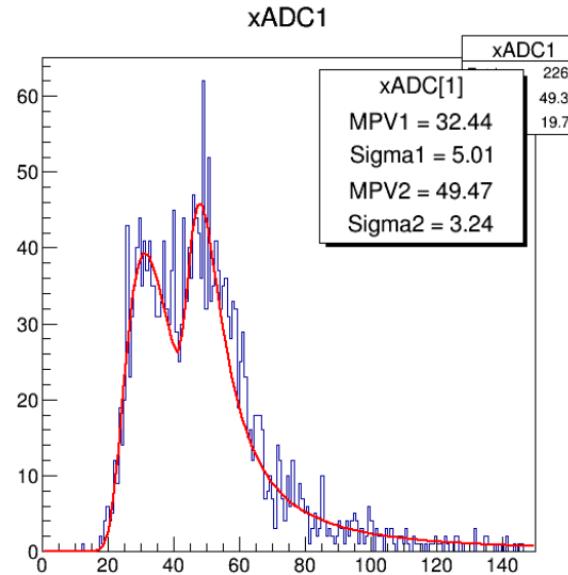
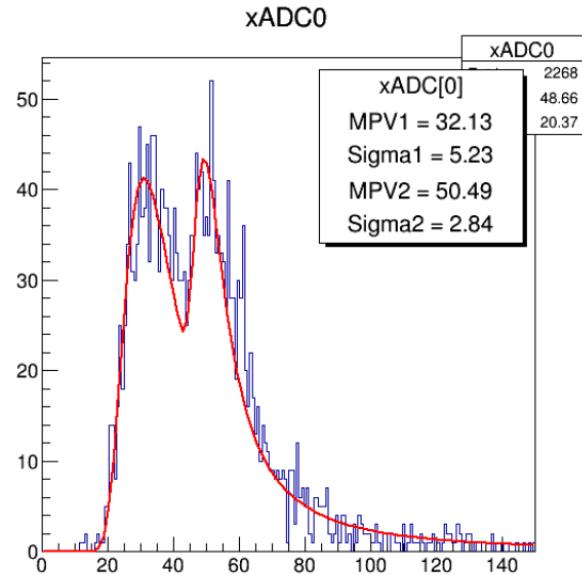
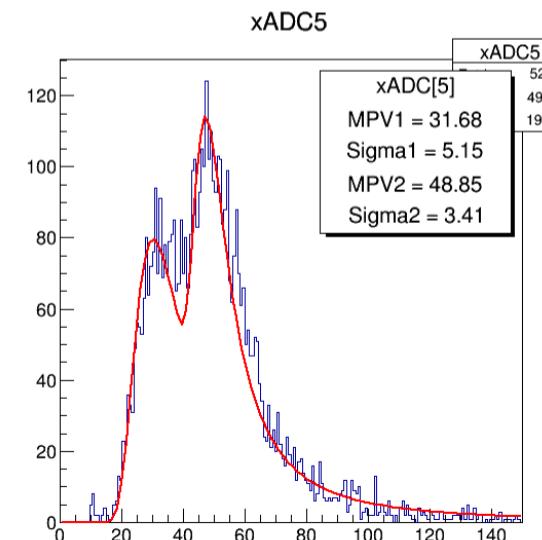
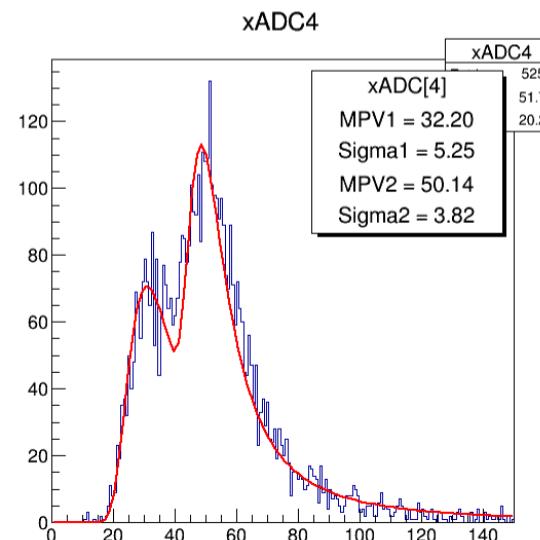
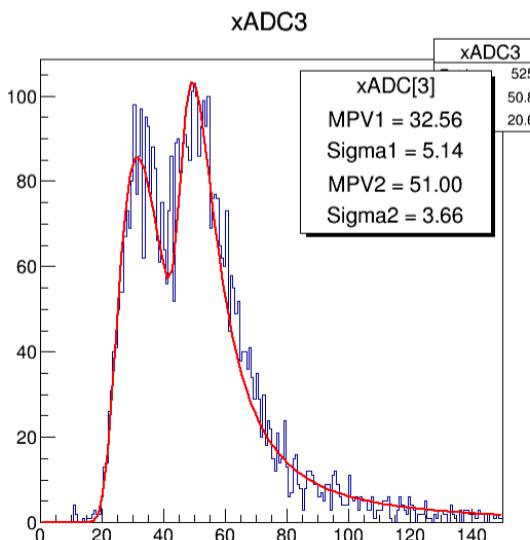
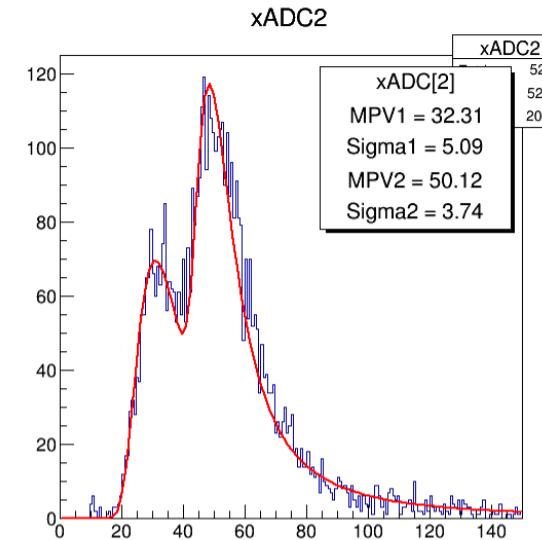
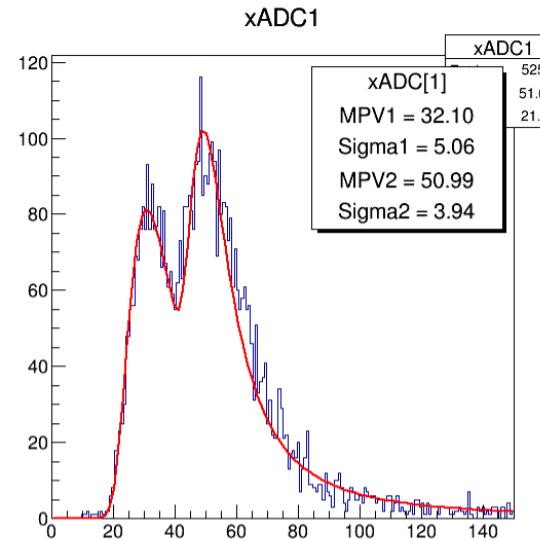
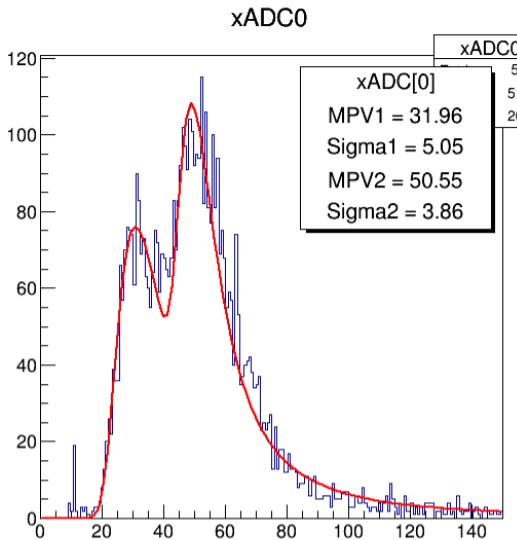


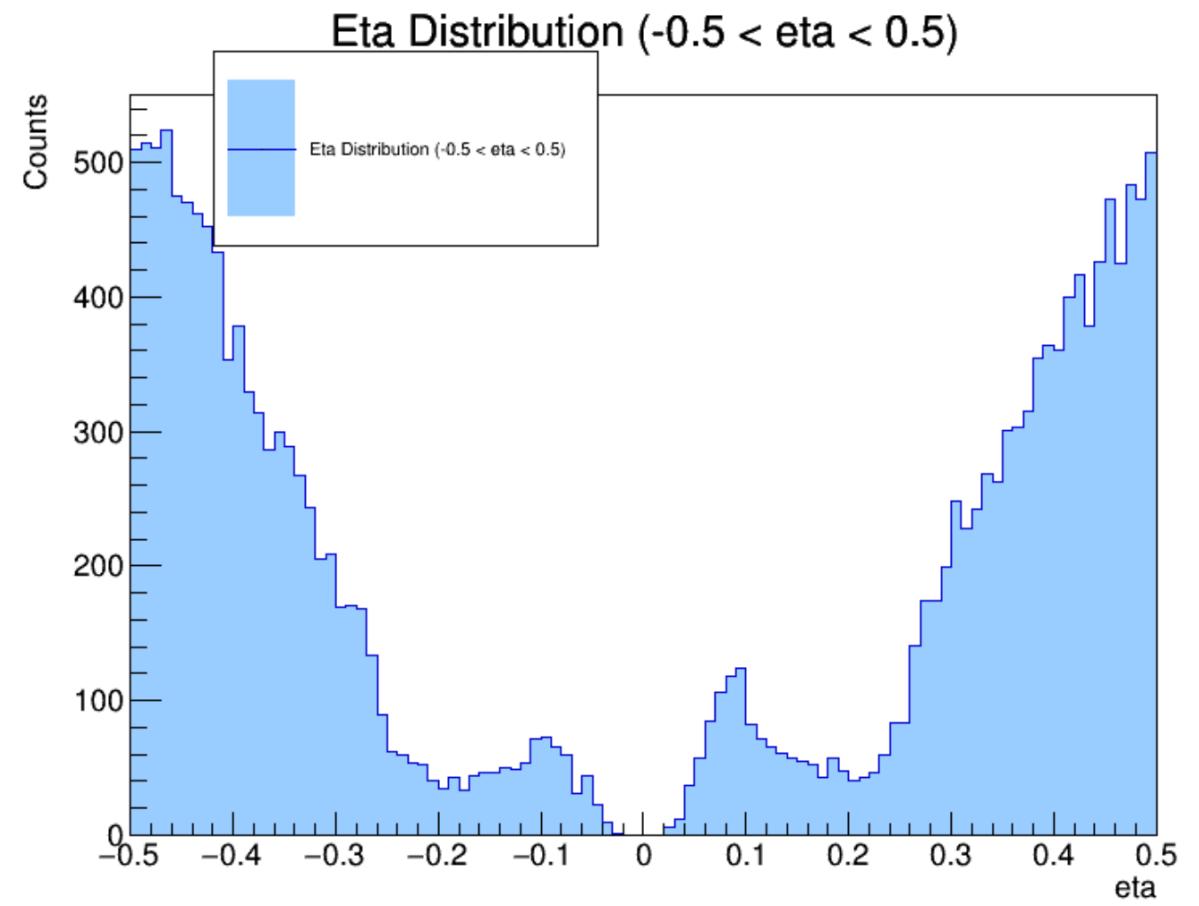
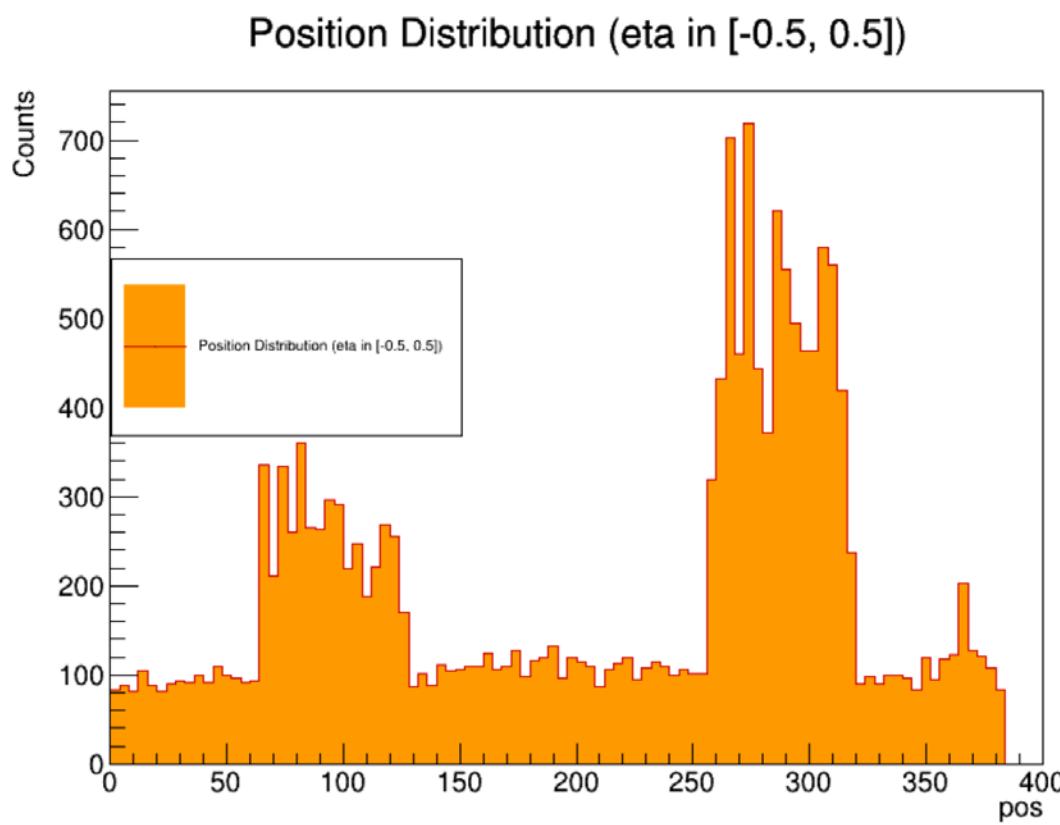
图 4.7 硅微条探测器的等效电路模型





With pb, VA增益校准?





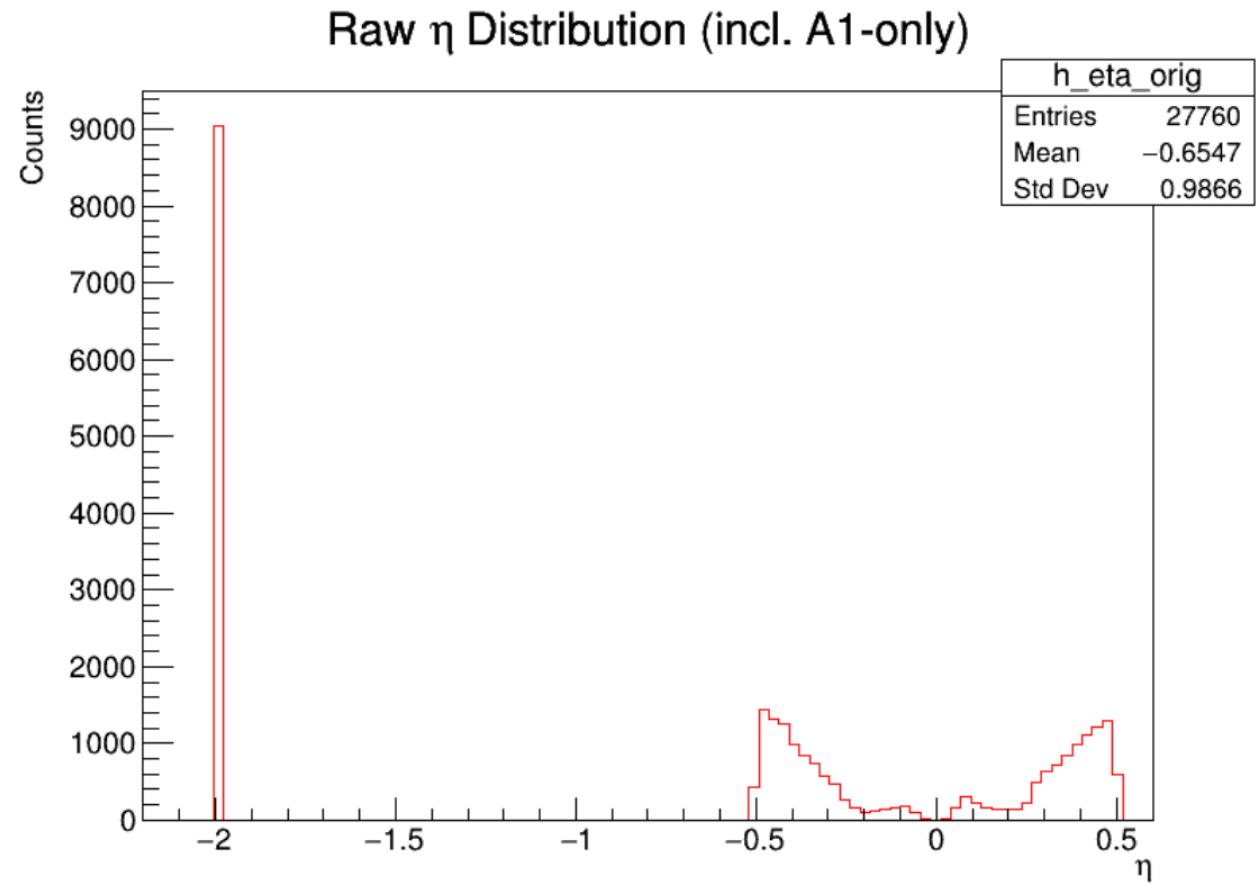
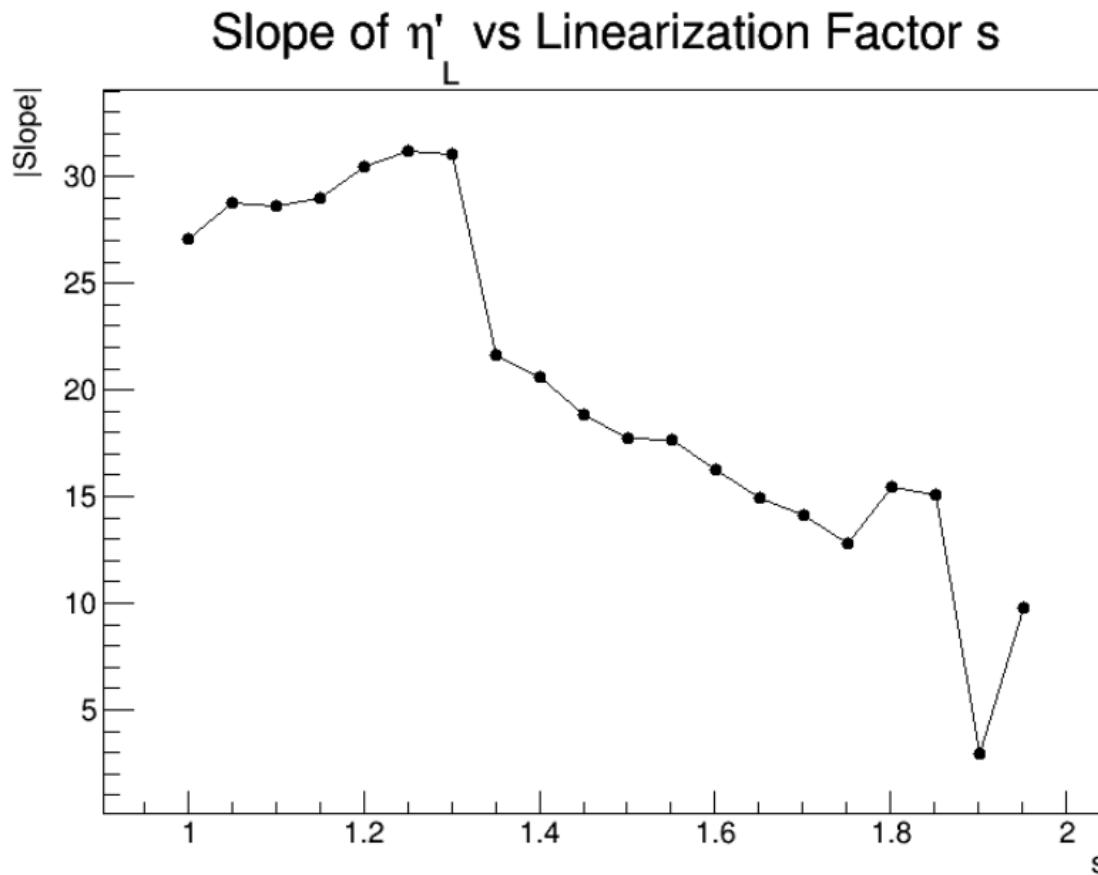
Eta修正

$$X_{\text{LIN}} = \eta' = \hat{s} \frac{A_2}{A_1 + A_2}.$$

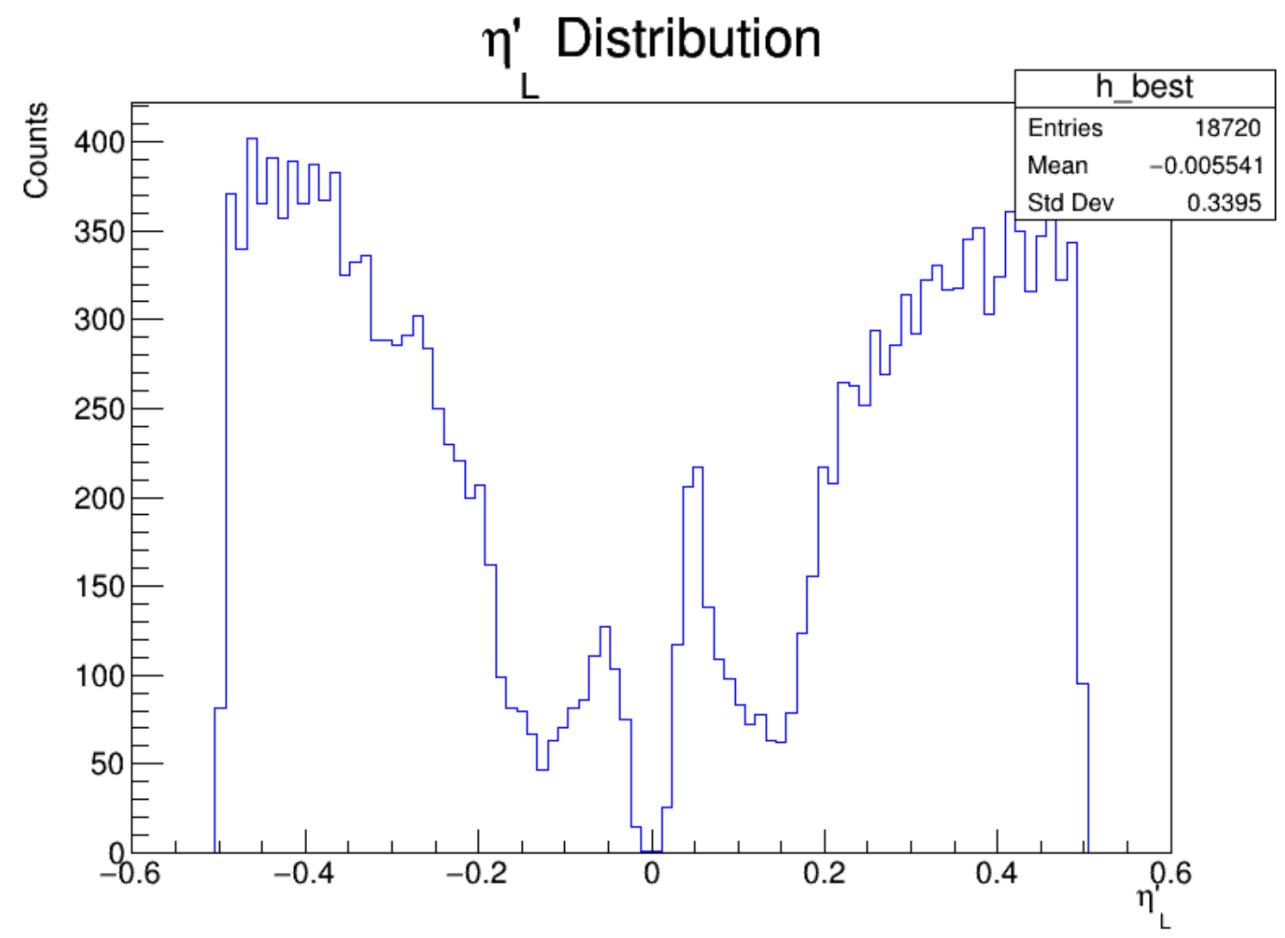
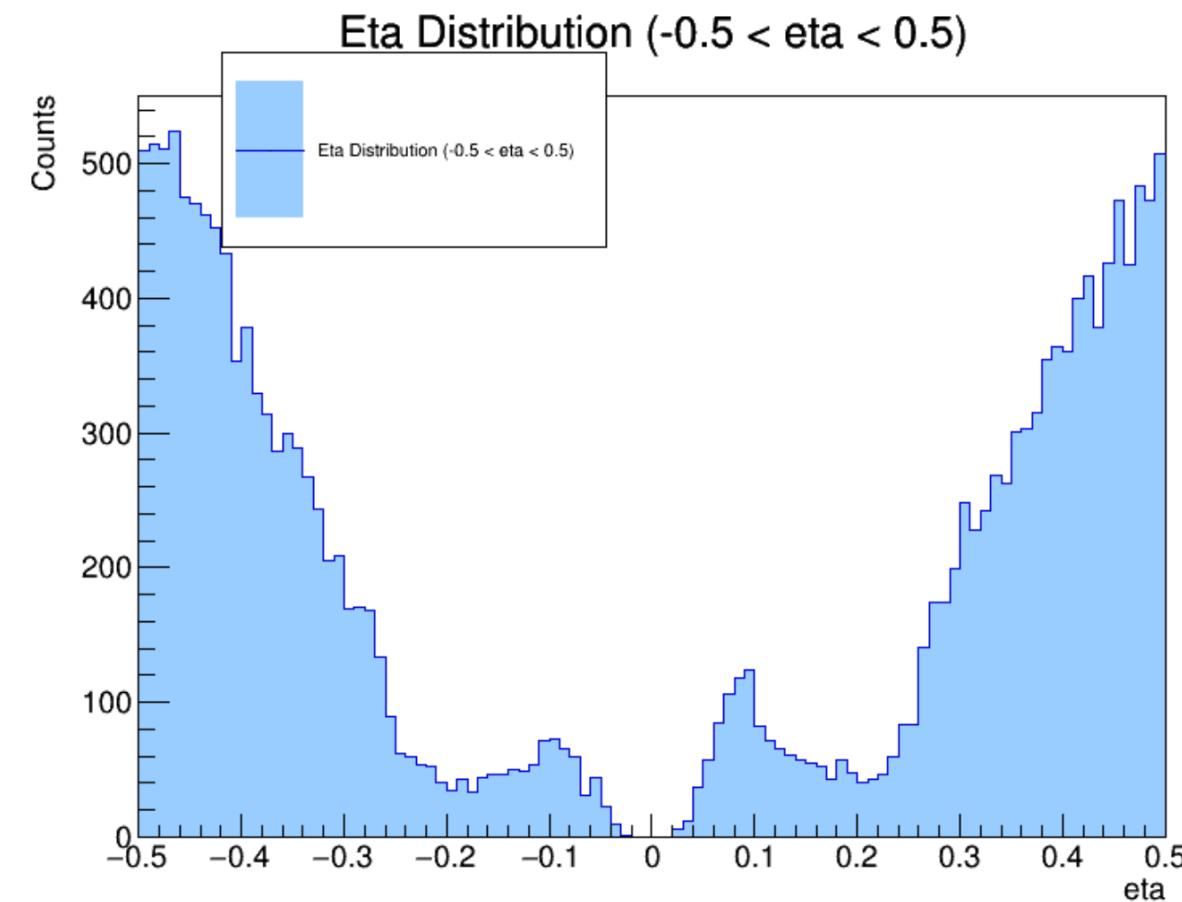
$$X_L = \eta'_L = \hat{s} \frac{A_2^m}{A_1^m + (s-1)(1-2|x|)A_1^m + A_2^m}$$

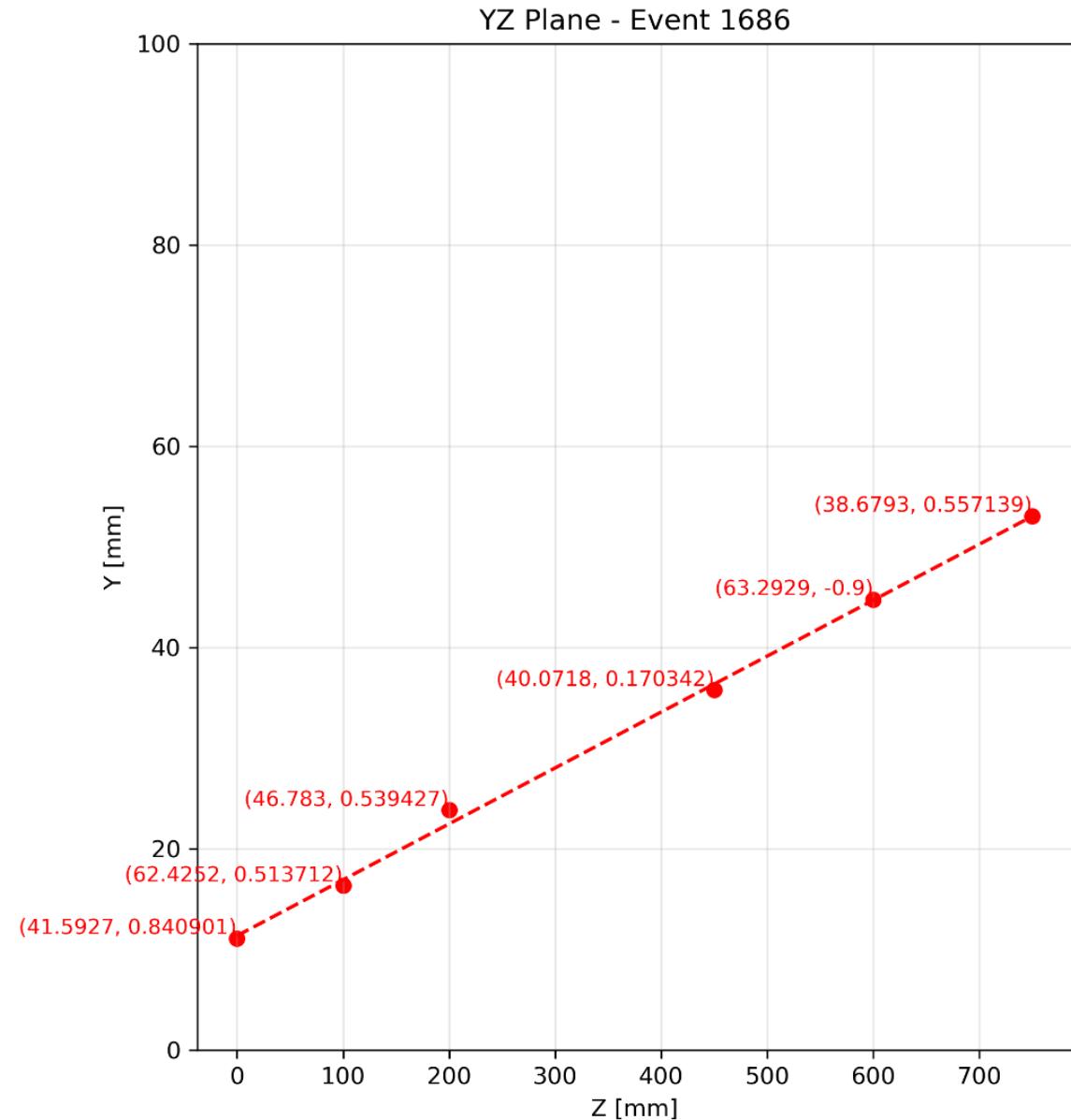
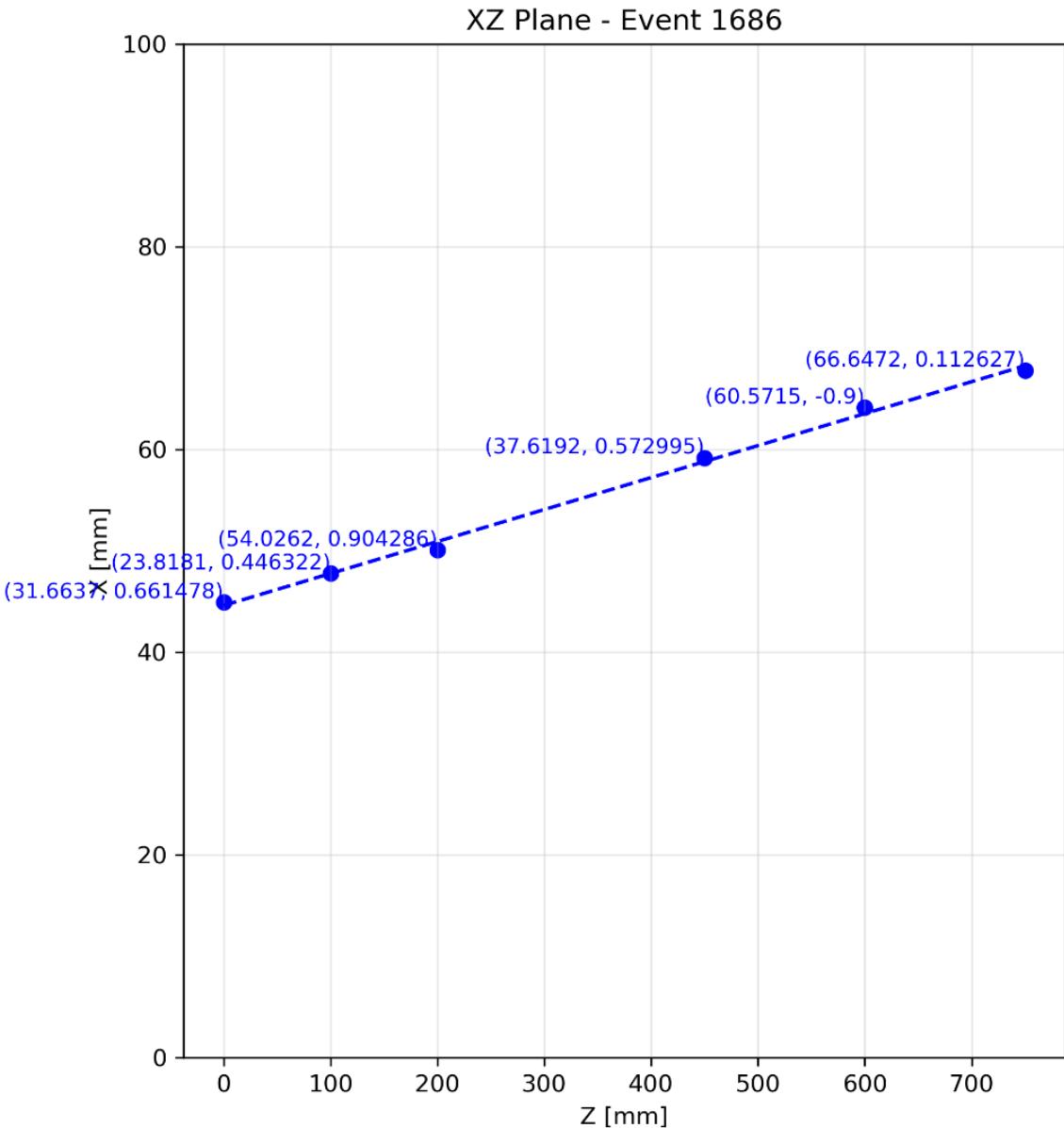
- S is the constant saturation scaling parameter, $s > 0$

Eta修正



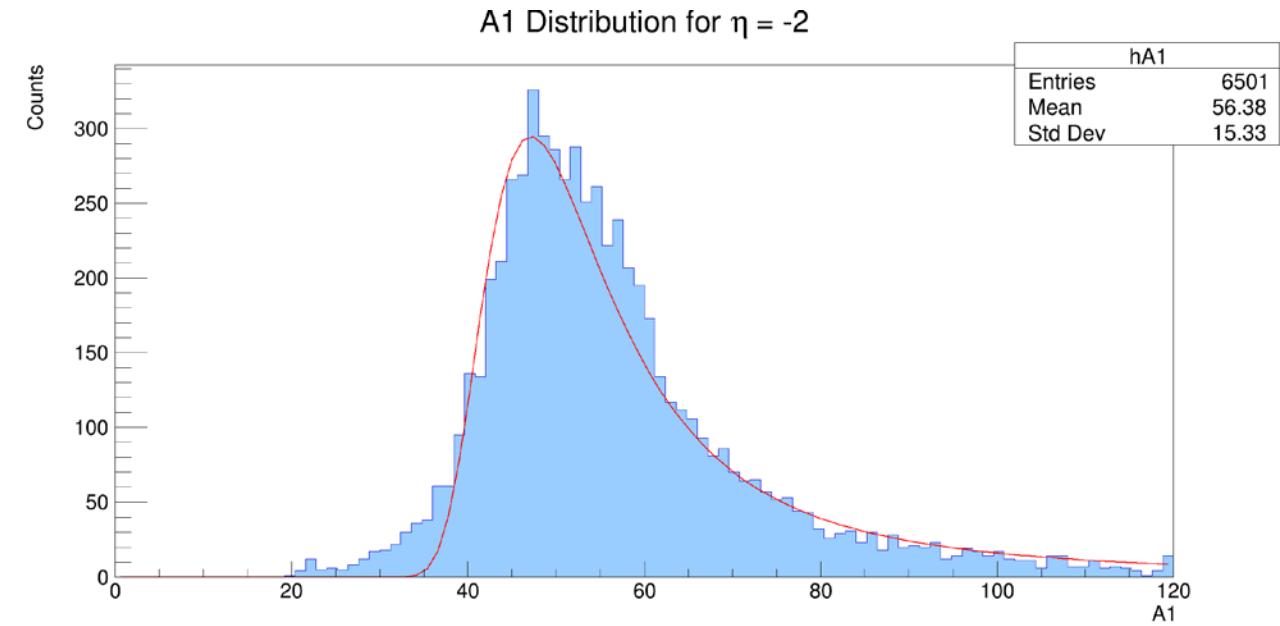
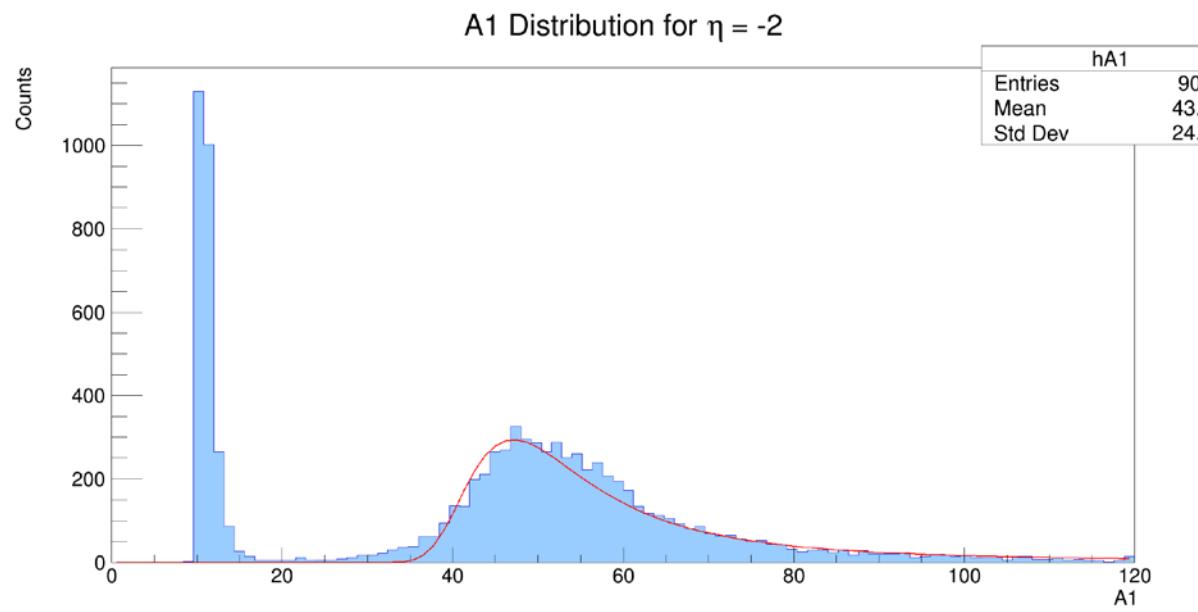
Eta修正





A1 only

- Calibrate VA gain
- flatter η and better linearity



紫台架子结构讨论

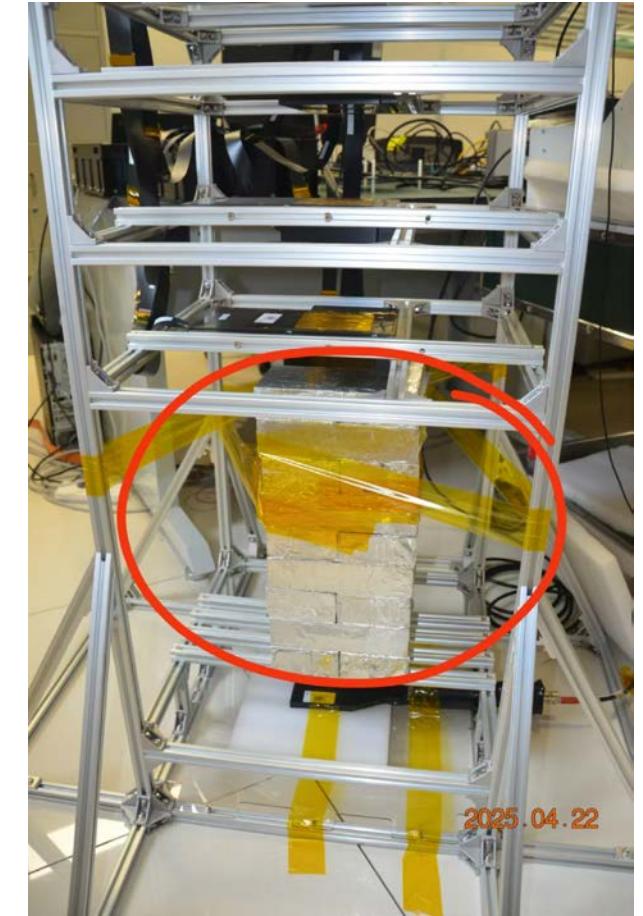
1.热膨胀, 采样记录的温度: <https://www.kdocs.cn/l/csdqp2YOjuhL>
20-26° 波动

铝合金, 2020铝型材, 热膨胀系数: $23.8 \times 10^{-6} /C^\circ$
总1.5m高左右, 高度形变: $23.8 \times 6 \times 1.5 = 214.2\mu m$

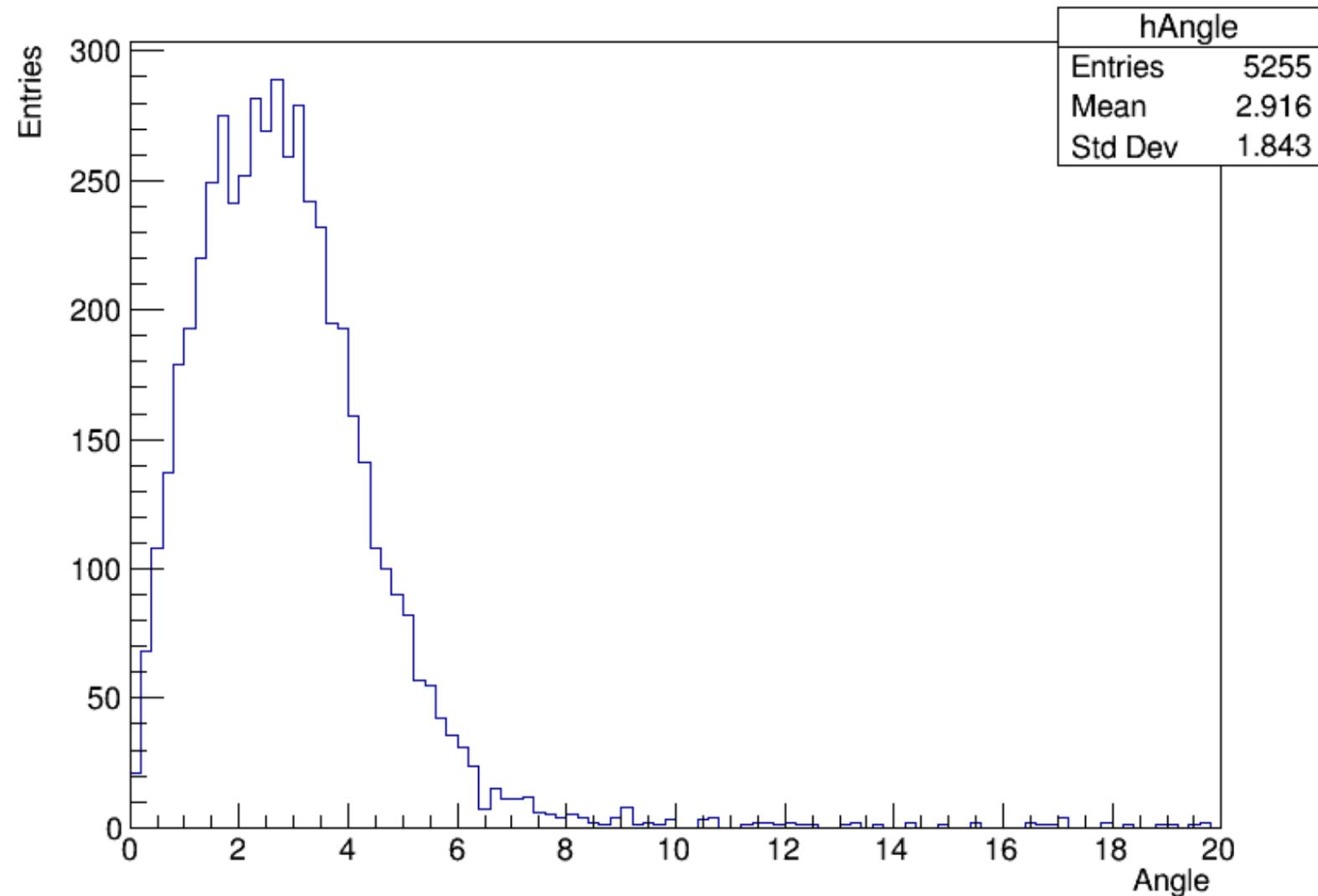
2.底部塑性形变, 金属疲劳, 螺栓连接形变

改进思路:

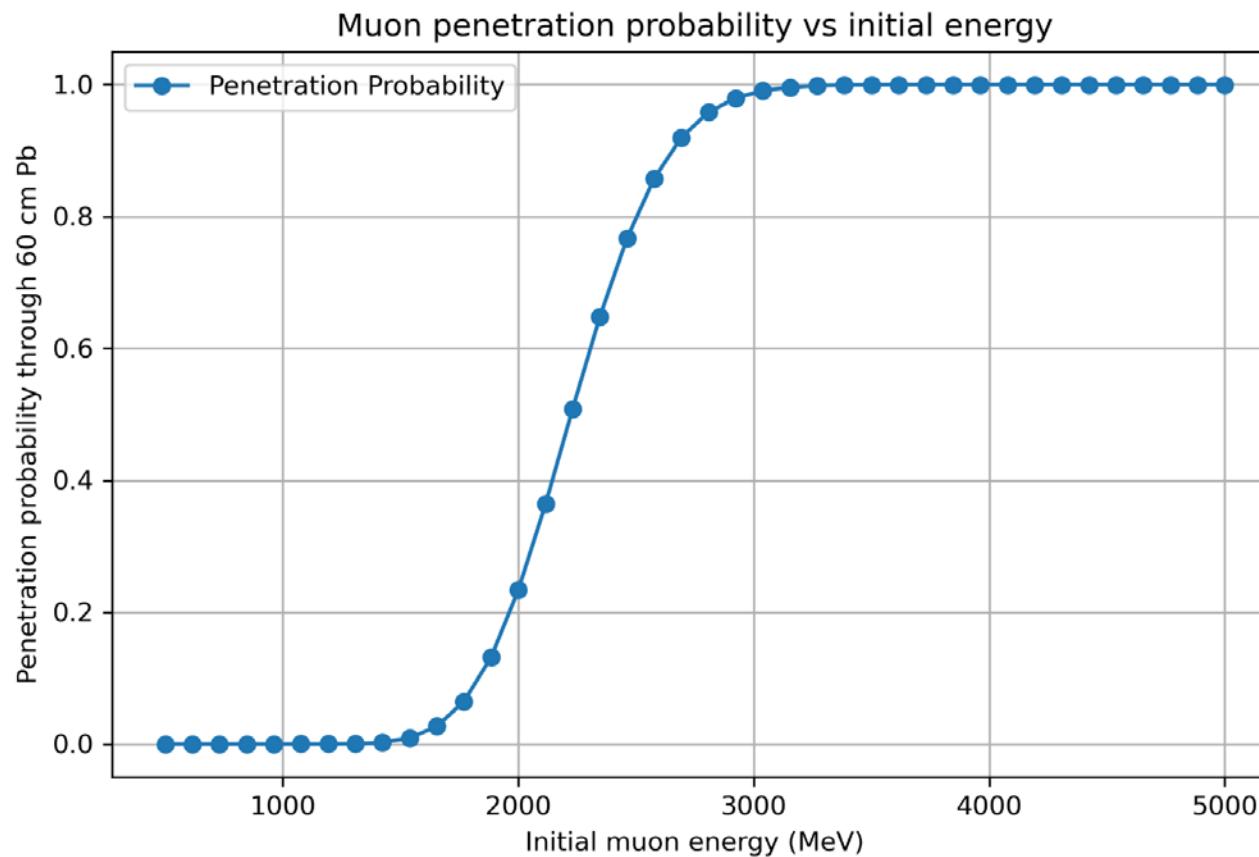
- 1.千斤顶垫住低端
- 2.贴应变片, 测每个点位的位移



Distribution angle of incoming tracks



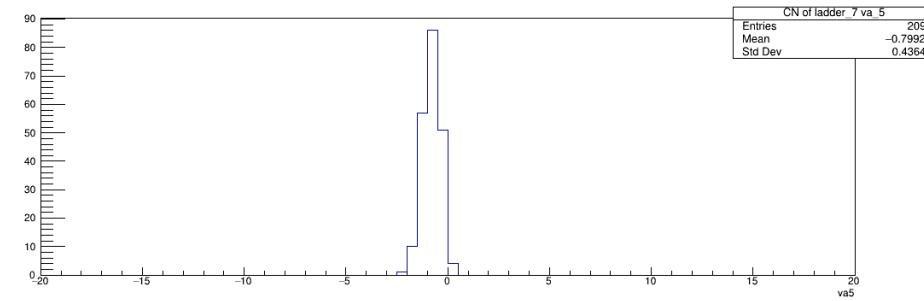
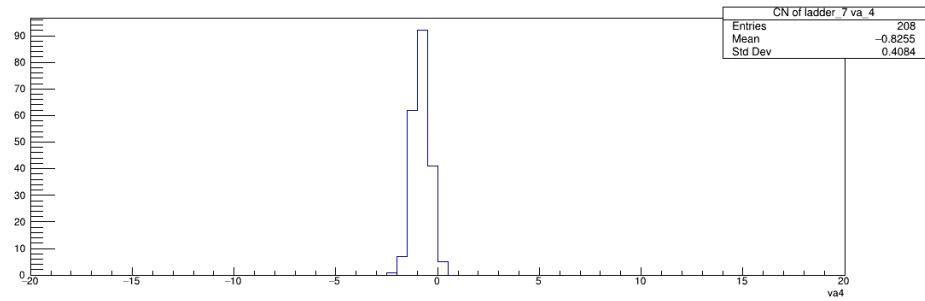
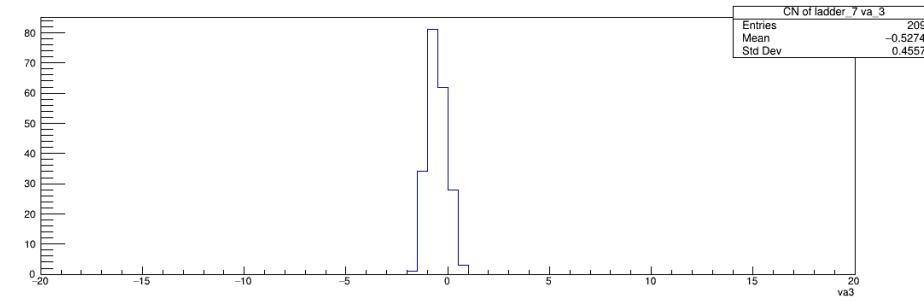
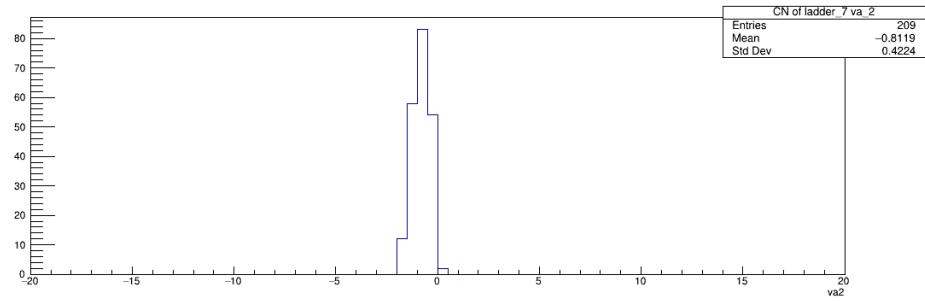
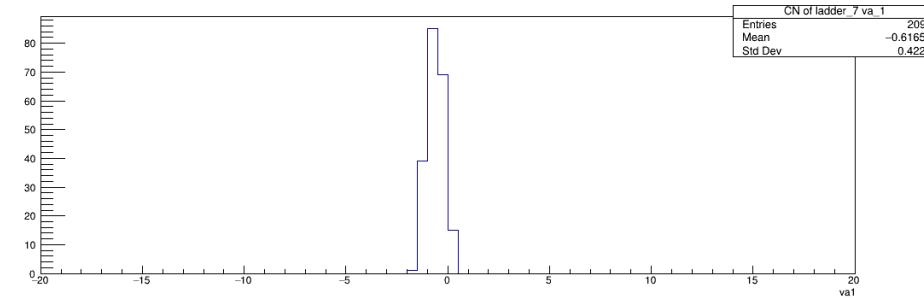
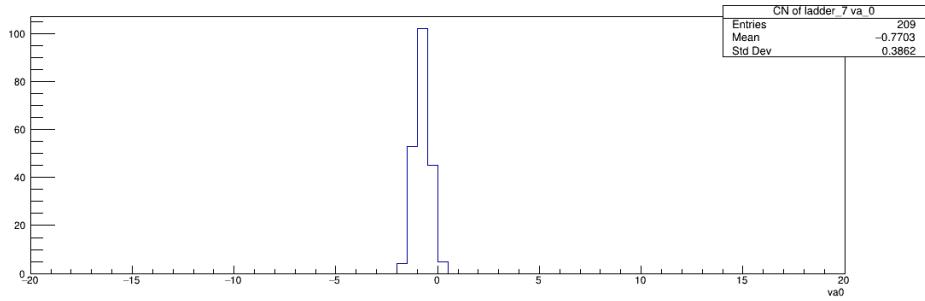
probability of penetrating 60 cm's Pb

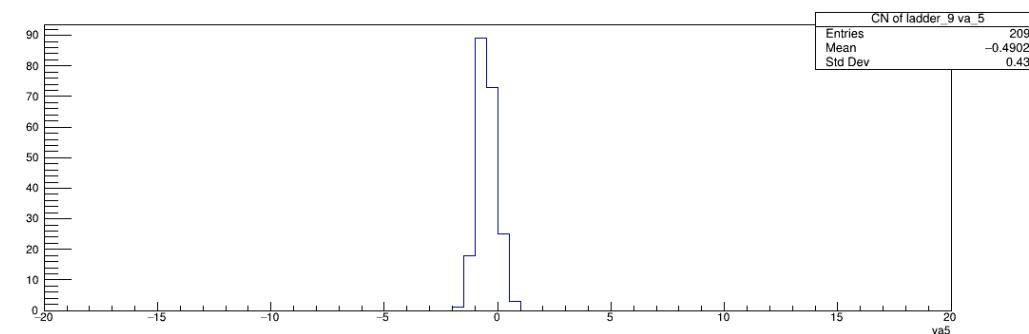
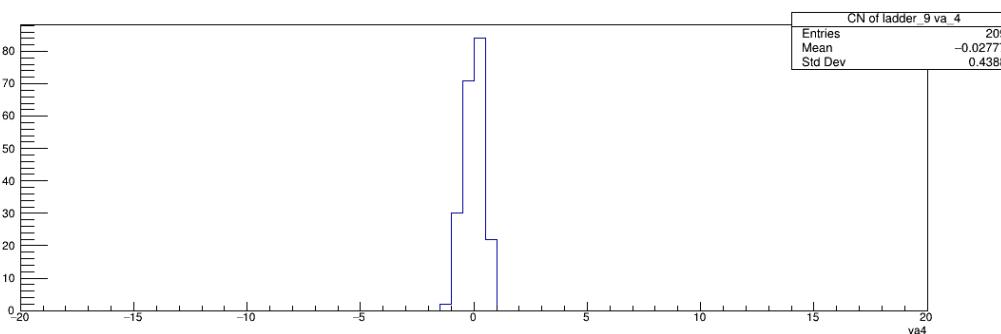
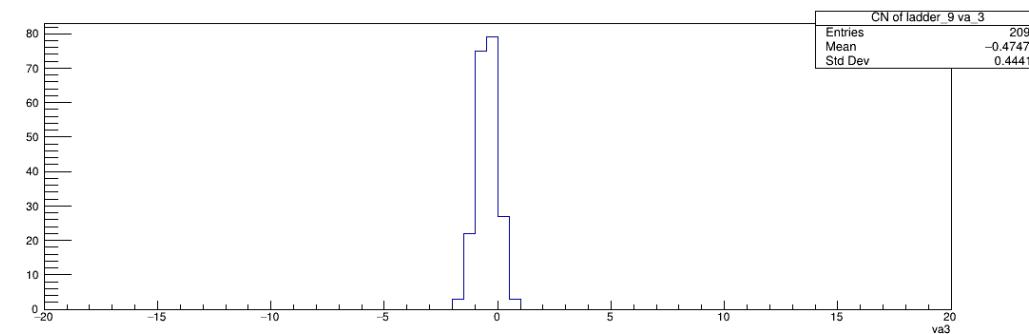
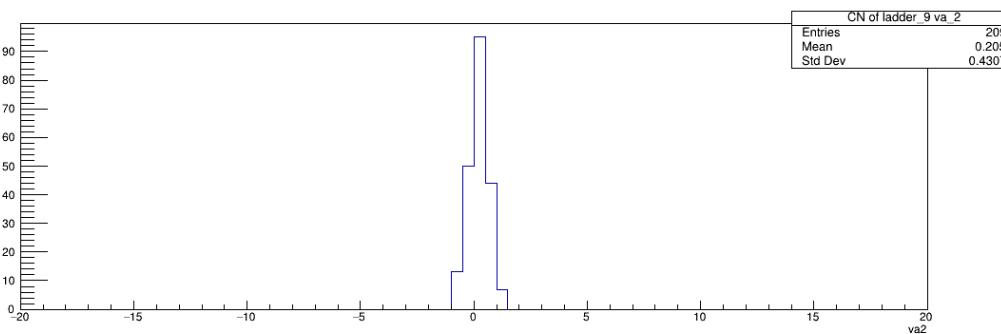
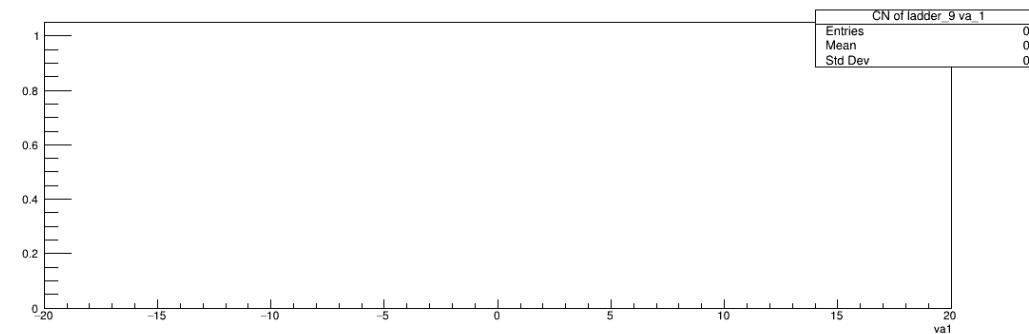
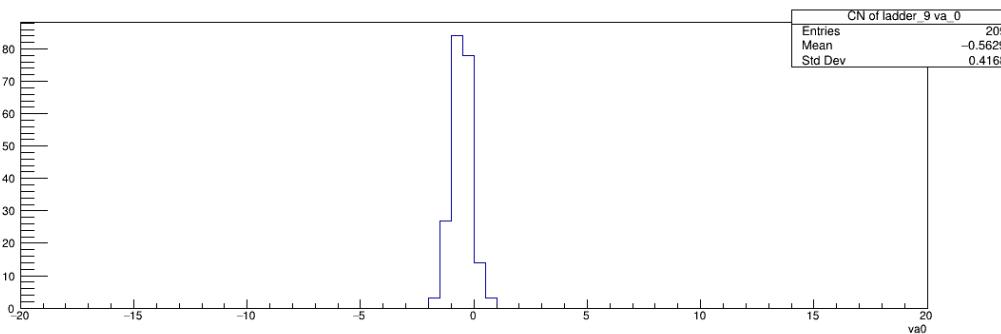


Discussion

- More precise processing of raw data to reduce residuals (though possibly very limited), achieving more accurate alignment and refraction angles.
- Or place more focus on the refraction angle in the Geant4 simulation.

- BACKUP

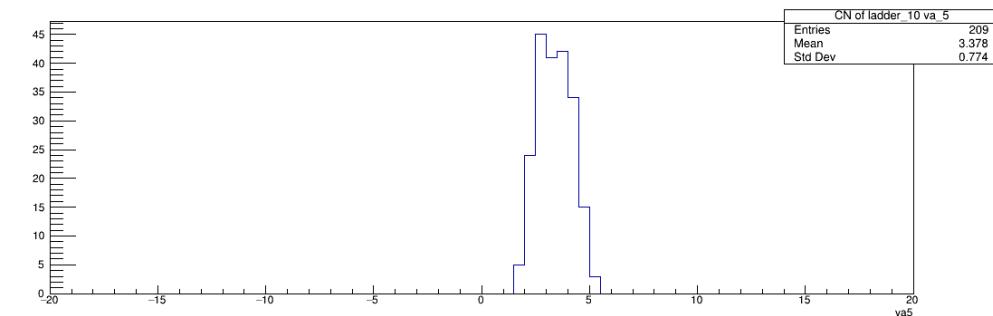
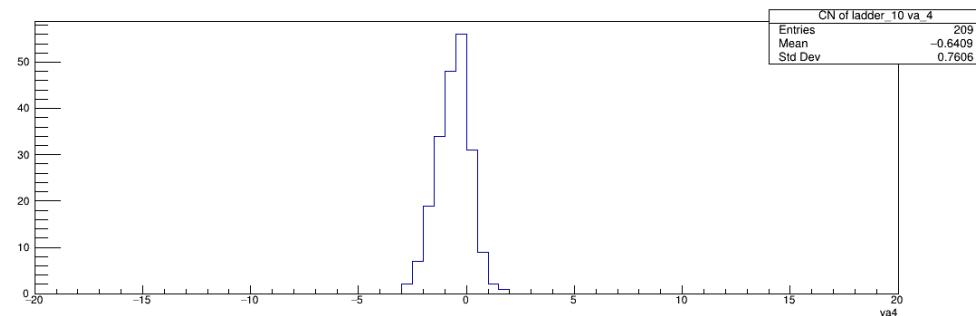
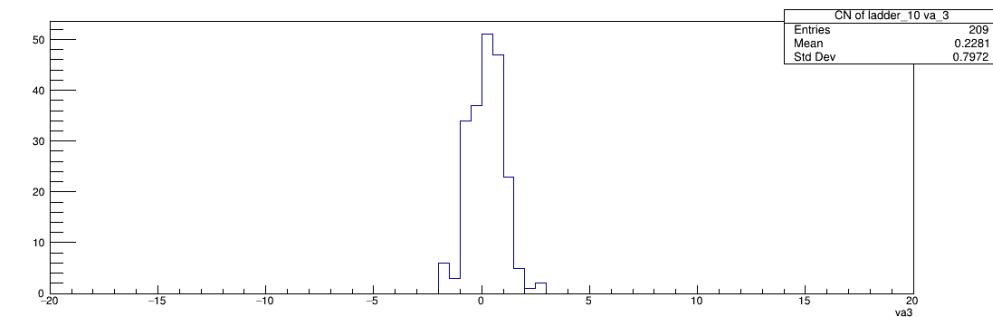
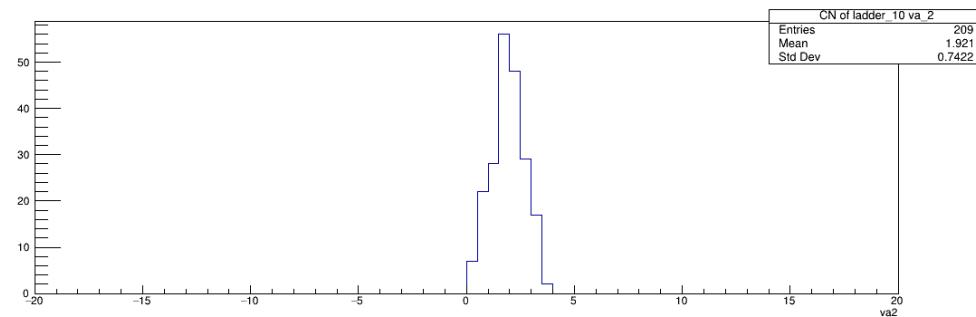
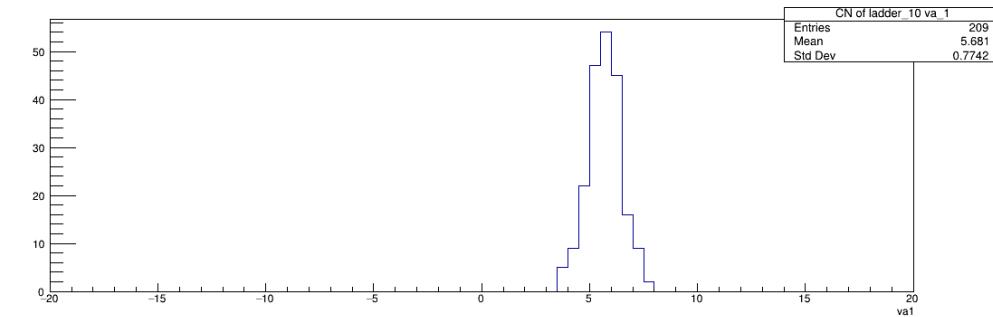
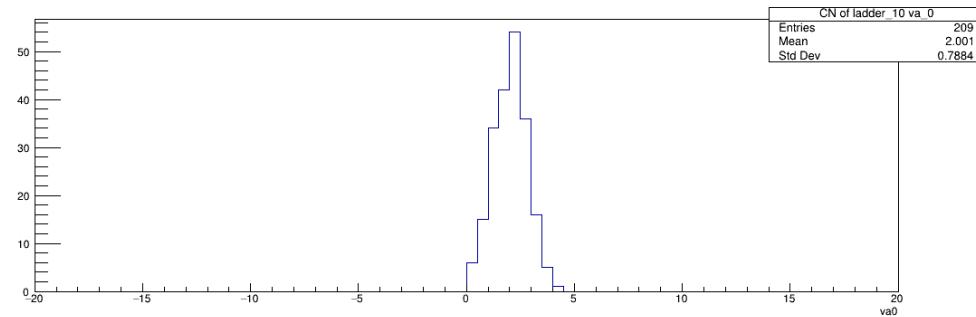




```

if(fabs(ADC[i][j] - pedestal[i][j]) < 20){ //1.5*noise

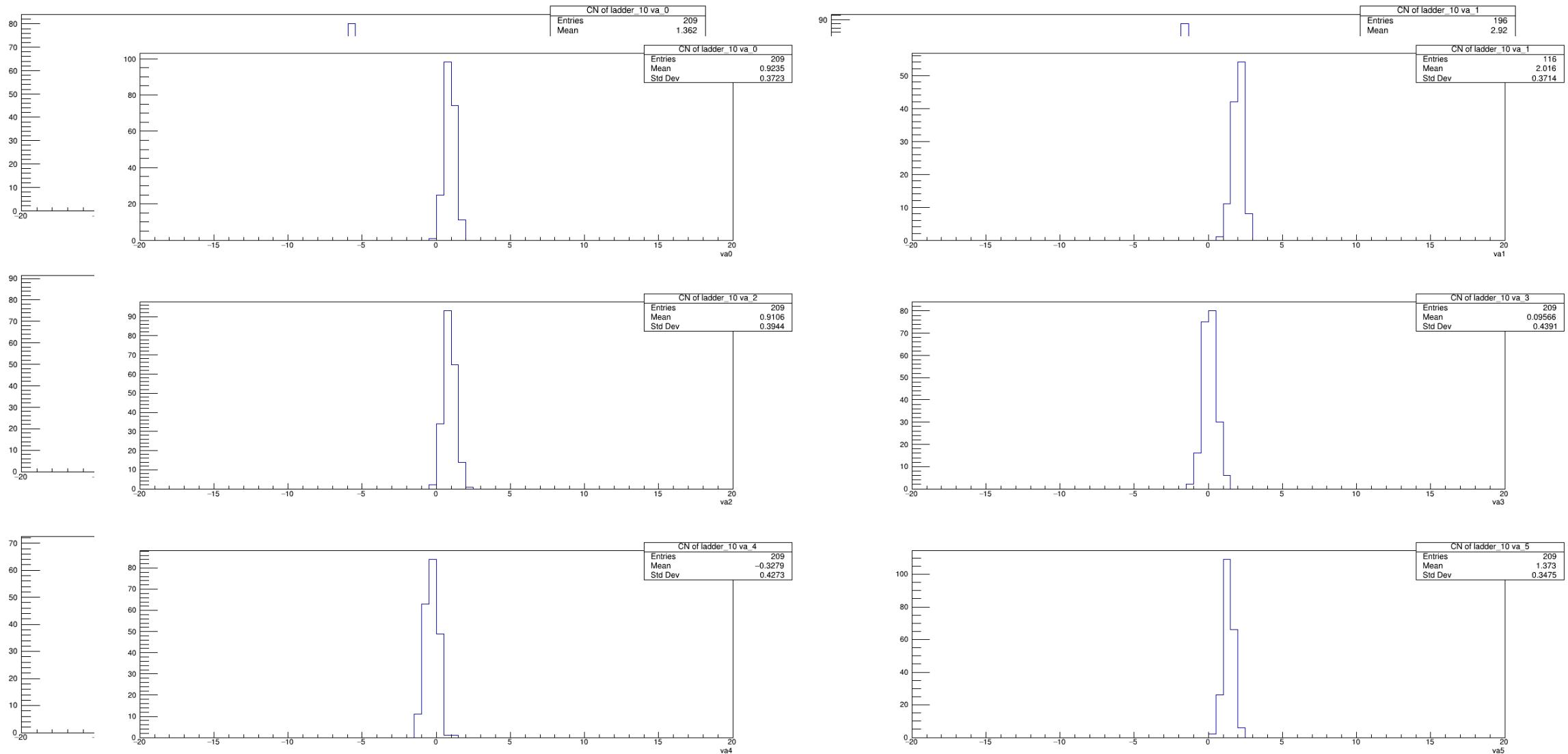
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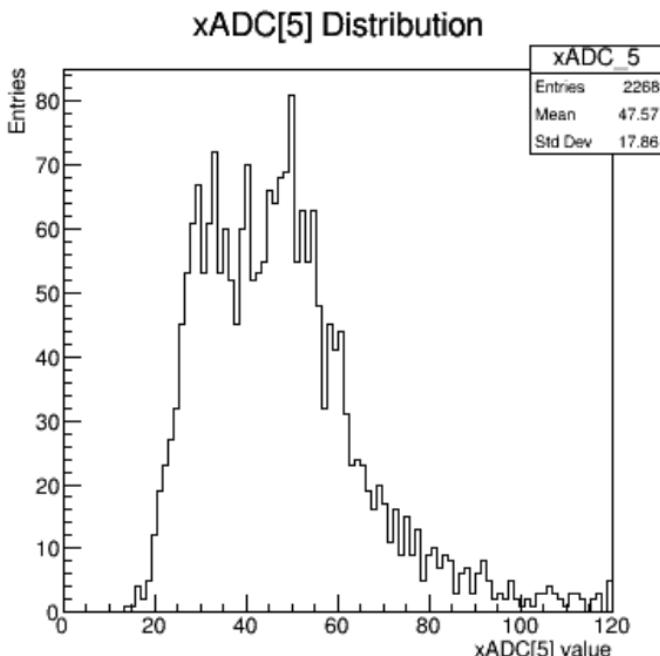
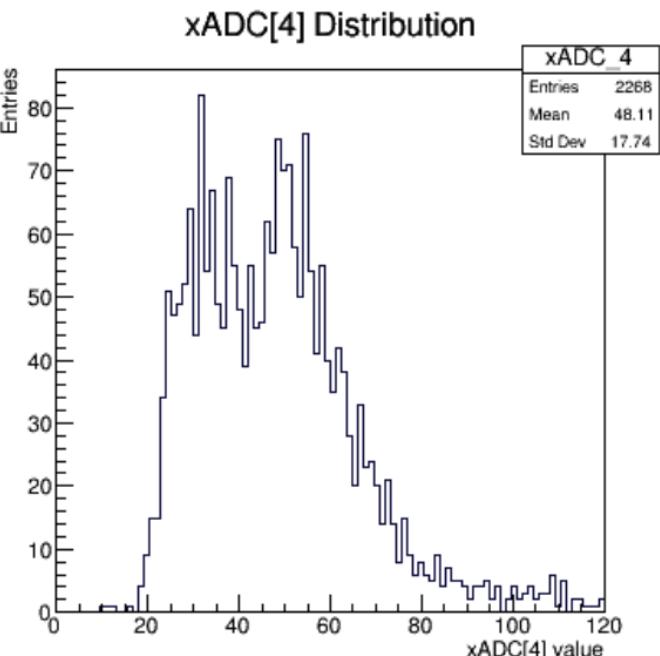
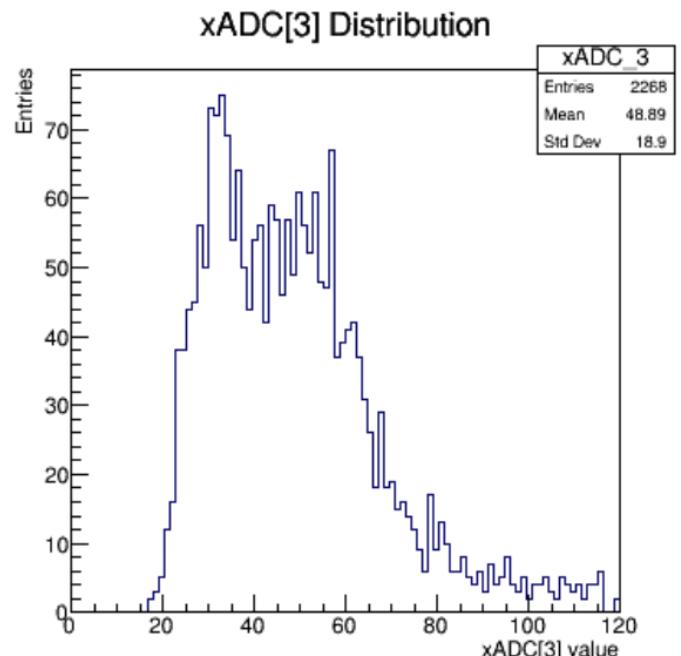
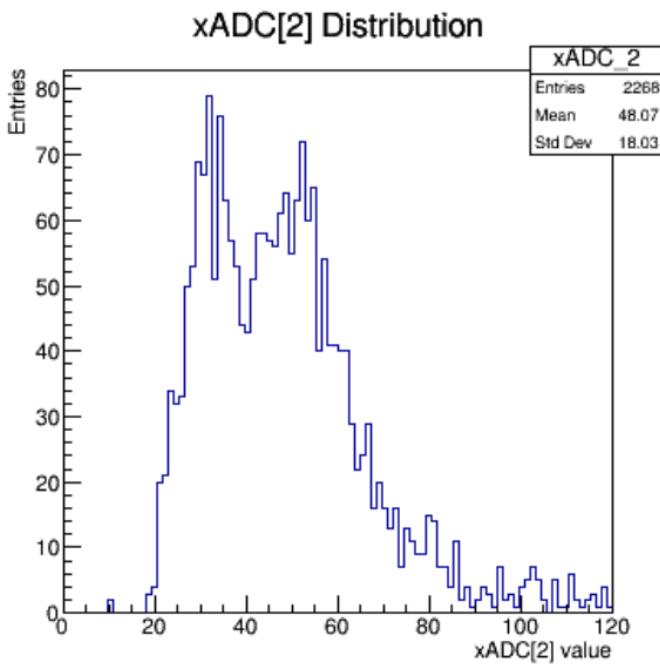
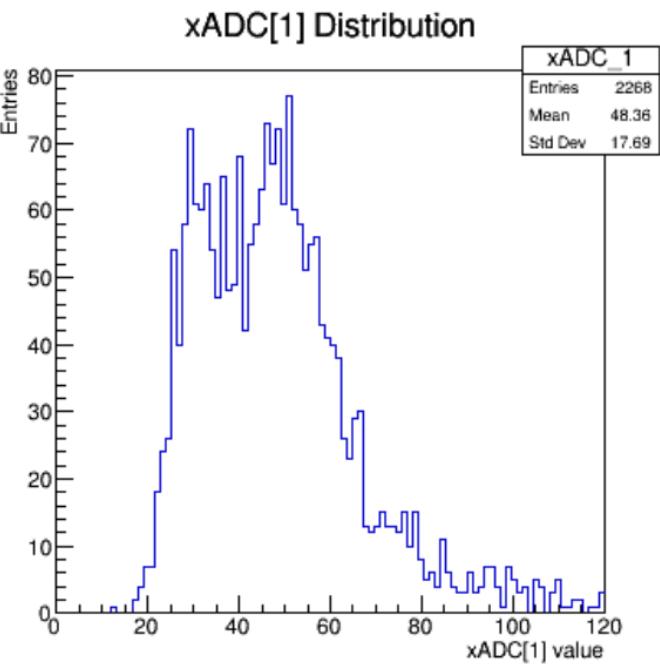
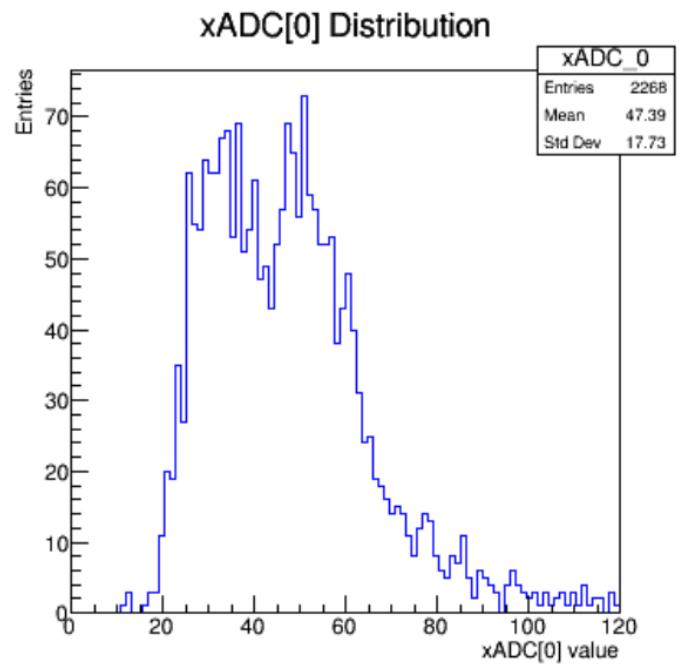


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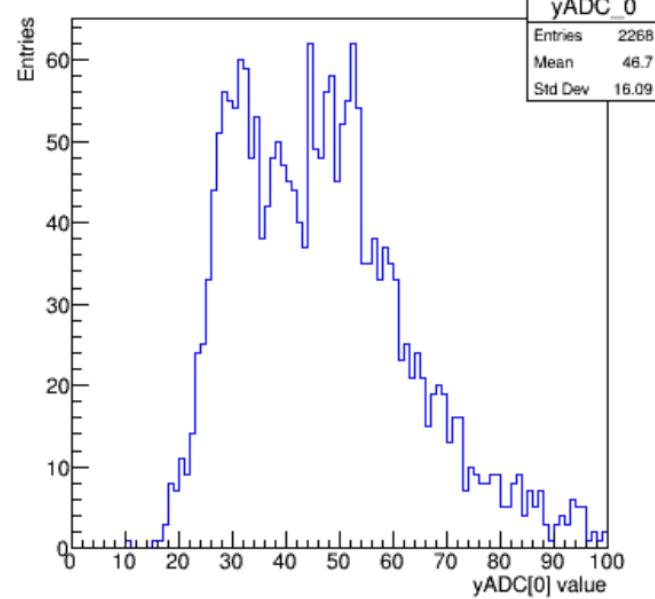
if(fabs(ADC[i][j] - pedestal[i][j]) < 2*noise[i][j])

```

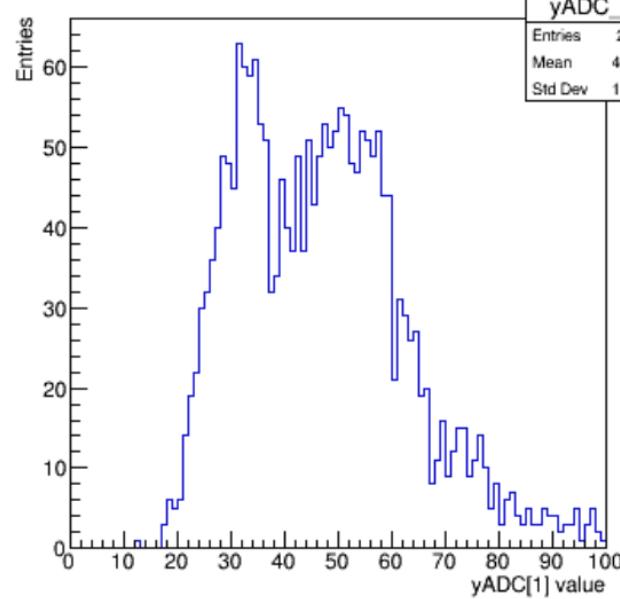




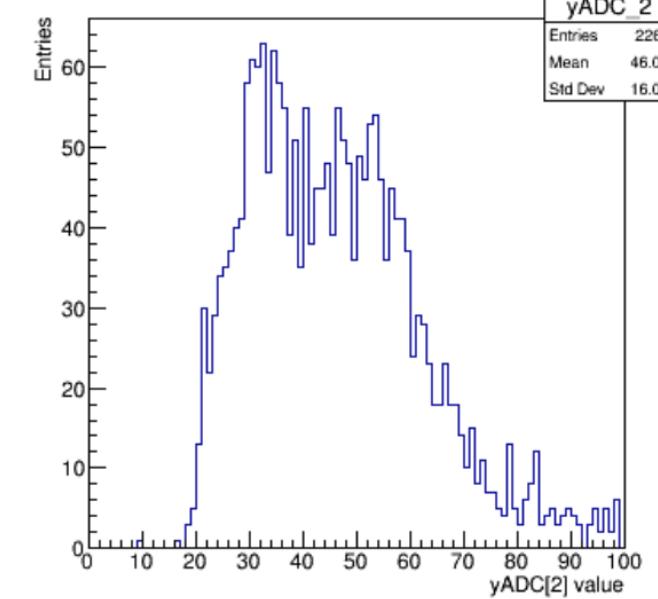
yADC[0] Distribution



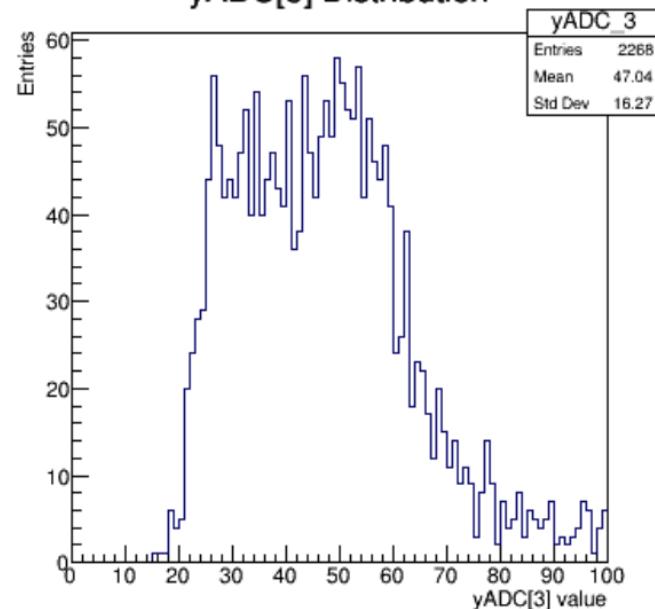
yADC[1] Distribution



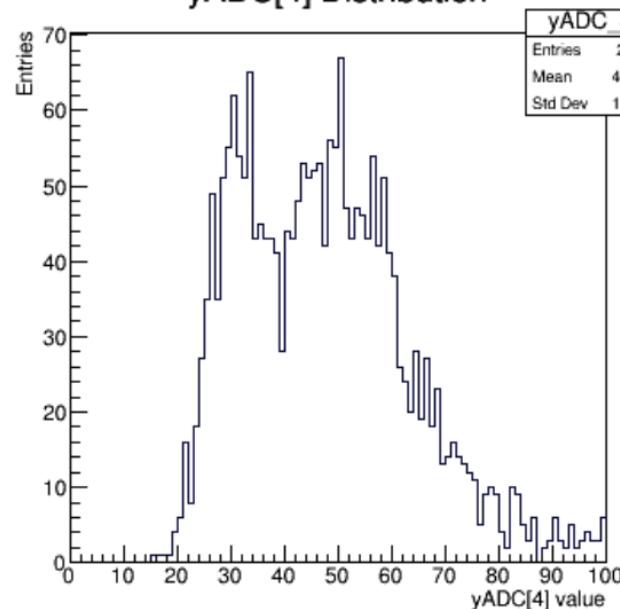
yADC[2] Distribution



yADC[3] Distribution



yADC[4] Distribution



yADC[5] Distribution

